



# *Heavy-ion induced molecular desorption: a review of three years of measurements at LINAC 3*



Edgar Mahner

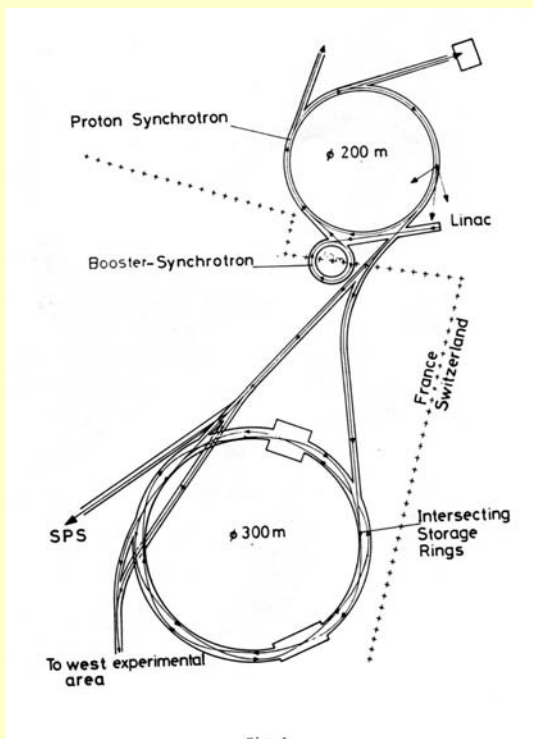
CERN, AT Division, Vacuum Group

## *Outline*

- Dynamic pressure rises at ISR and LEAR
- LEIR vacuum requirements
- Review of LINAC 3 desorption studies
- Desorption experiment at the SPS

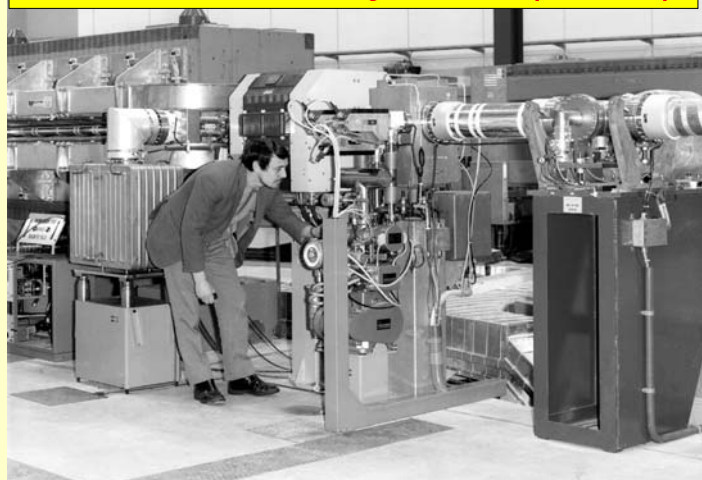
*13<sup>th</sup> ICFA Beam Dynamics Mini-Workshop  
Beam Induced Pressure Rise in Rings  
Brookhaven National Laboratory, December 9 - 12, 2003*

# CERN Intersecting Storage Rings (ISR)



pp collisions (26 GeV)

## ISR vacuum system (1971)



Length:  $\sim 2 \times 1$  km (double ring)  
 Average pressure:  $10^{-9}$  Torr  
 Material: stainless steel  
 Bakeout:  $300^\circ\text{C}$

ISR design study (May 1964)

## ISR tunnel (1983)



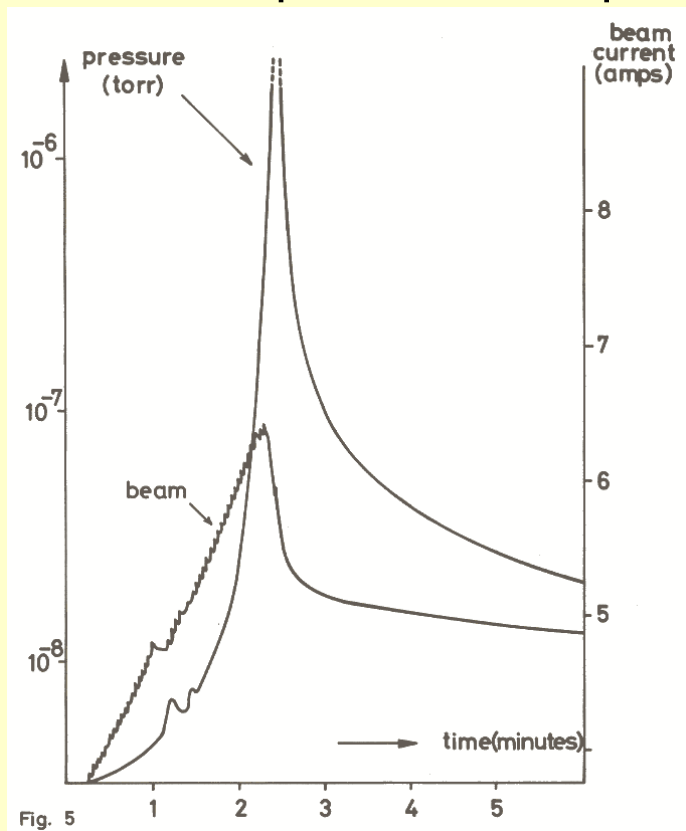
## ISR tunnel (2001)

# ISR pressure rise

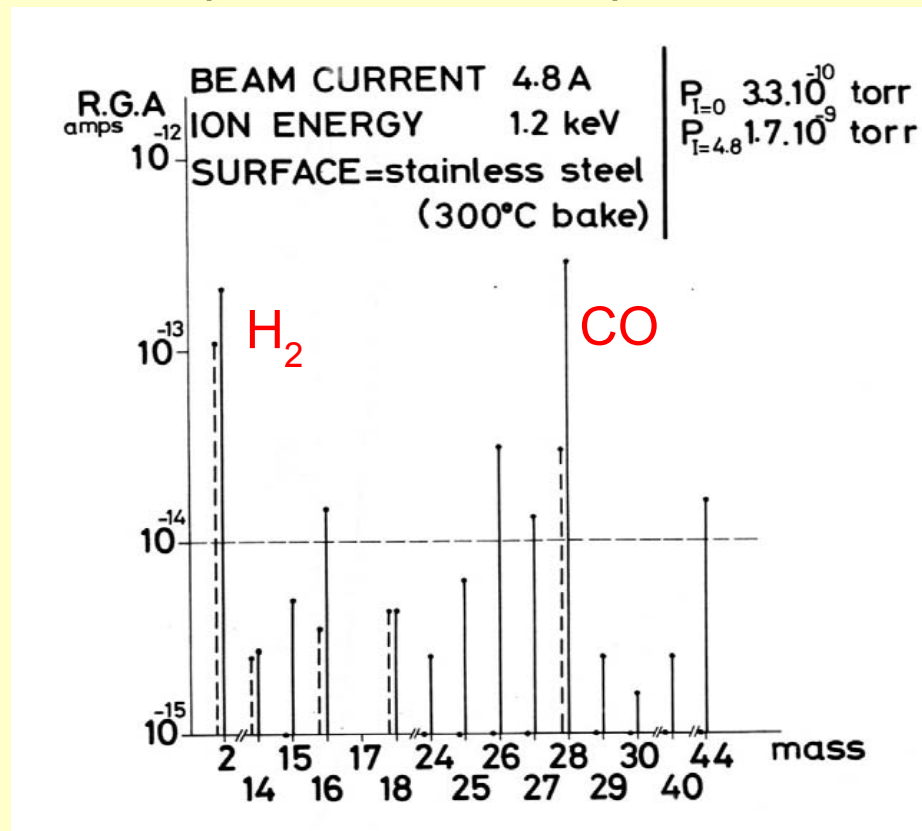
First observation of “ion-induced” vacuum instability



## The ISR pressure bump



## Gas composition of a ISR pressure bump



O. Gröbner and R.S. Calder (1973)

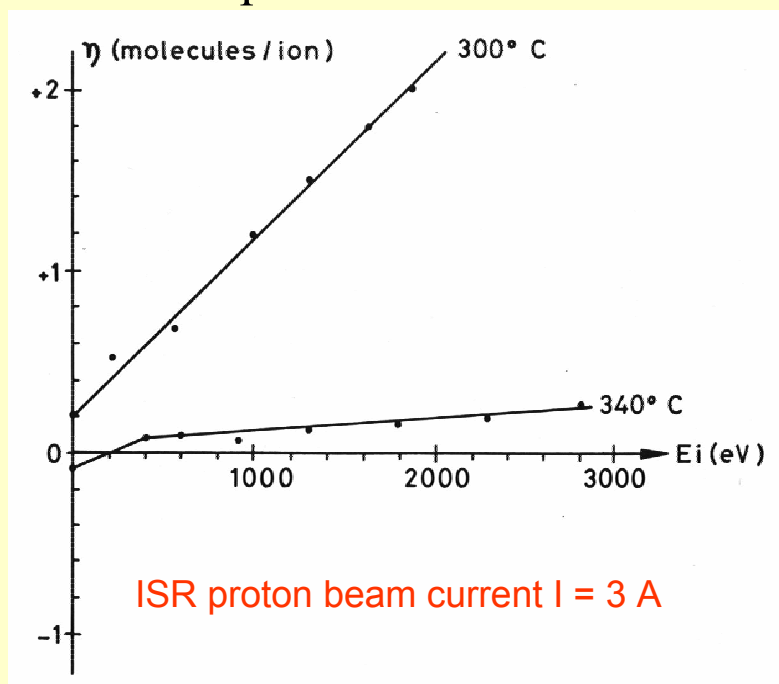


# Cure of the ISR pressure rise

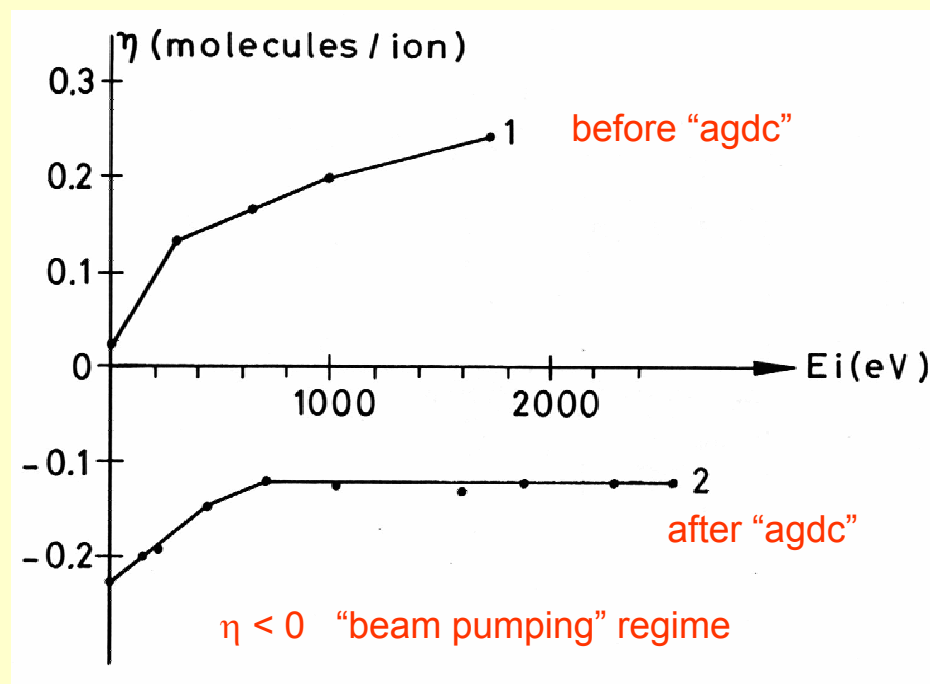
Desorption yield depends on surface treatments



Dependence on bakeout temperature



Argon glow discharge cleaning (agdc) + *in-situ* bakeout at 300°C



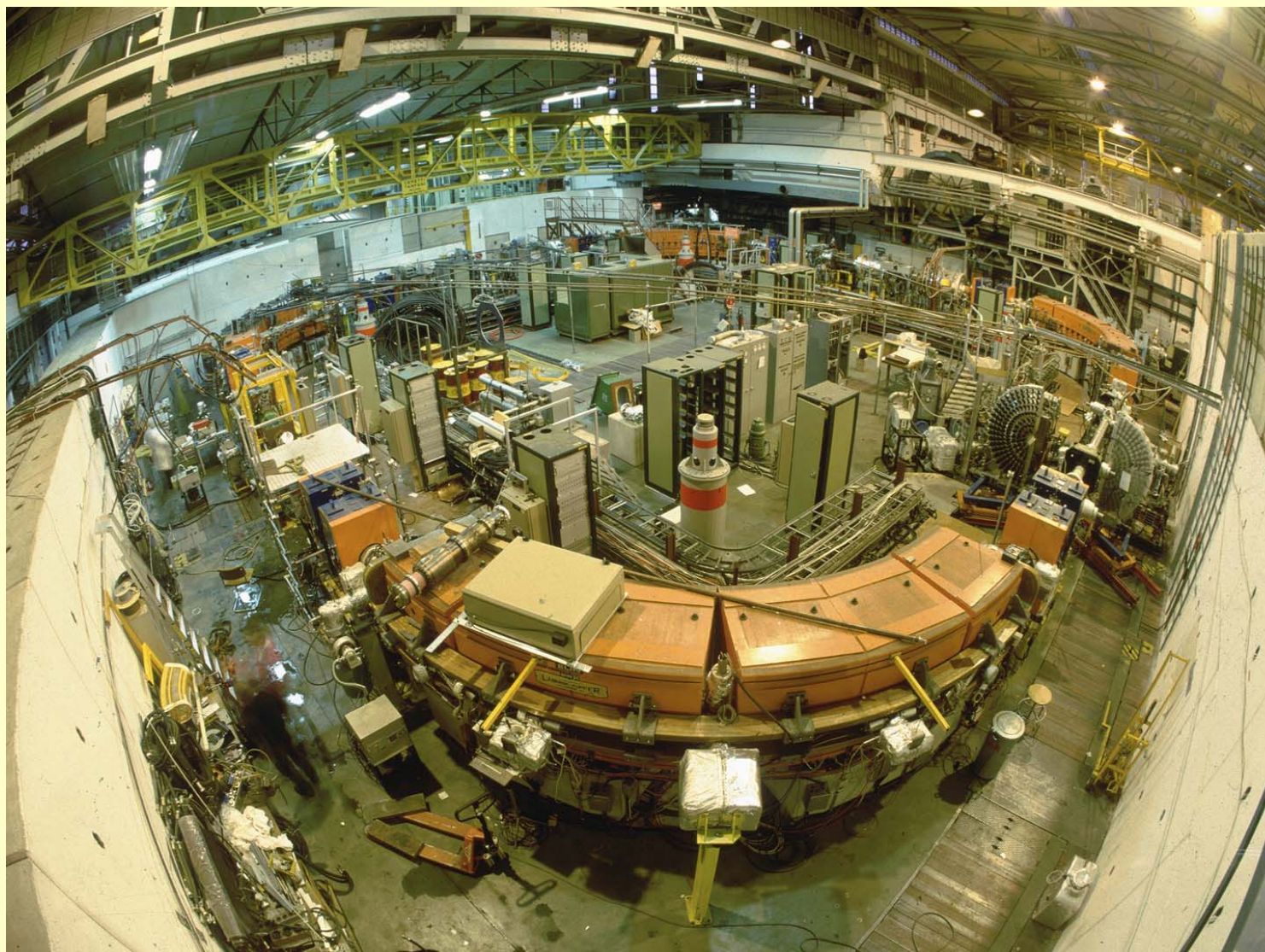
**Cure for the ISR:** Improvement of the pumping system + reduction of desorption yield due to improved bakeouts and/or glow discharge cleaning

O. Gröbner and R.S. Calder (1973)





# *LEAR ring 1997*



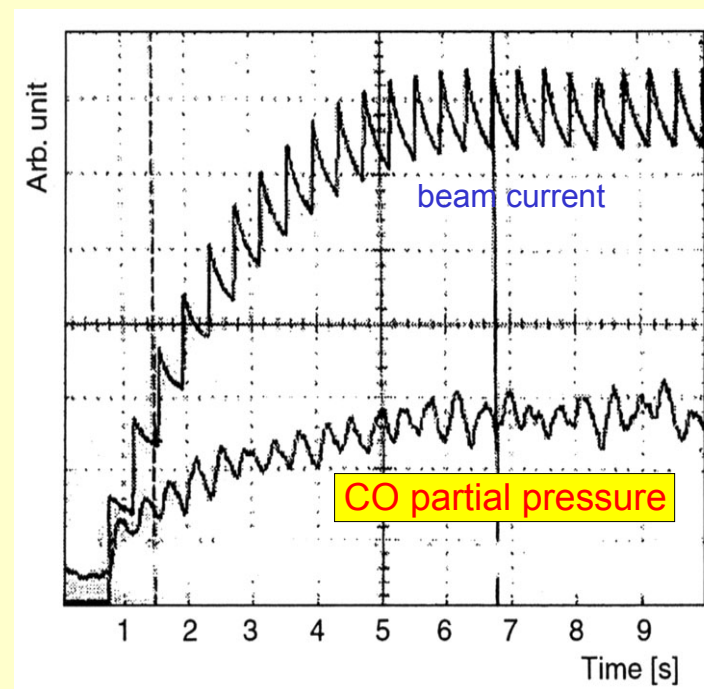
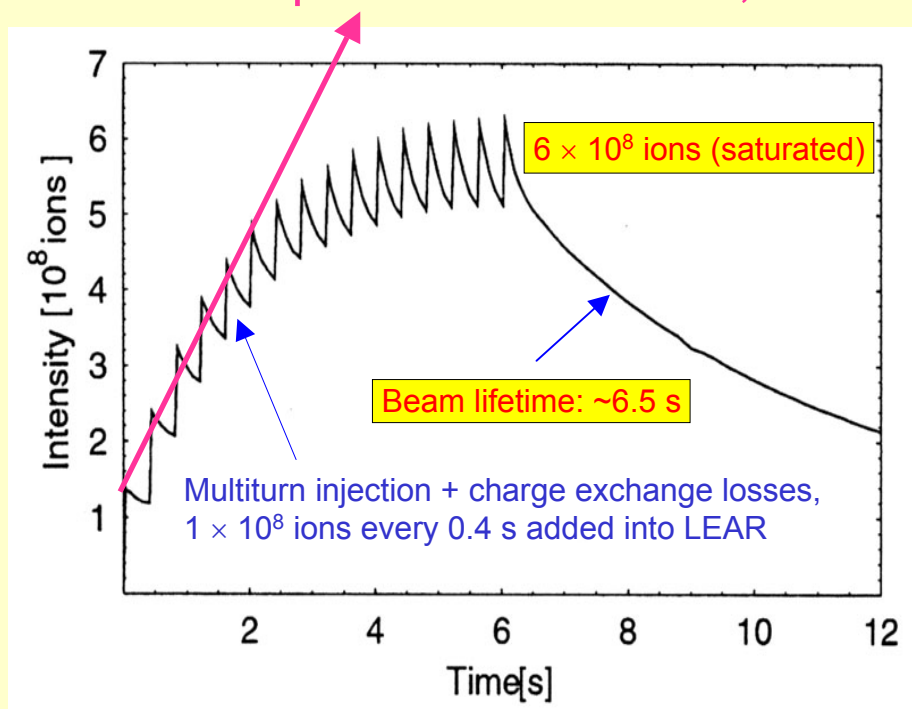


# *Ion-induced pressure rise during $Pb^{54+}$ (4.2 MeV/u) accumulation in LEAR*



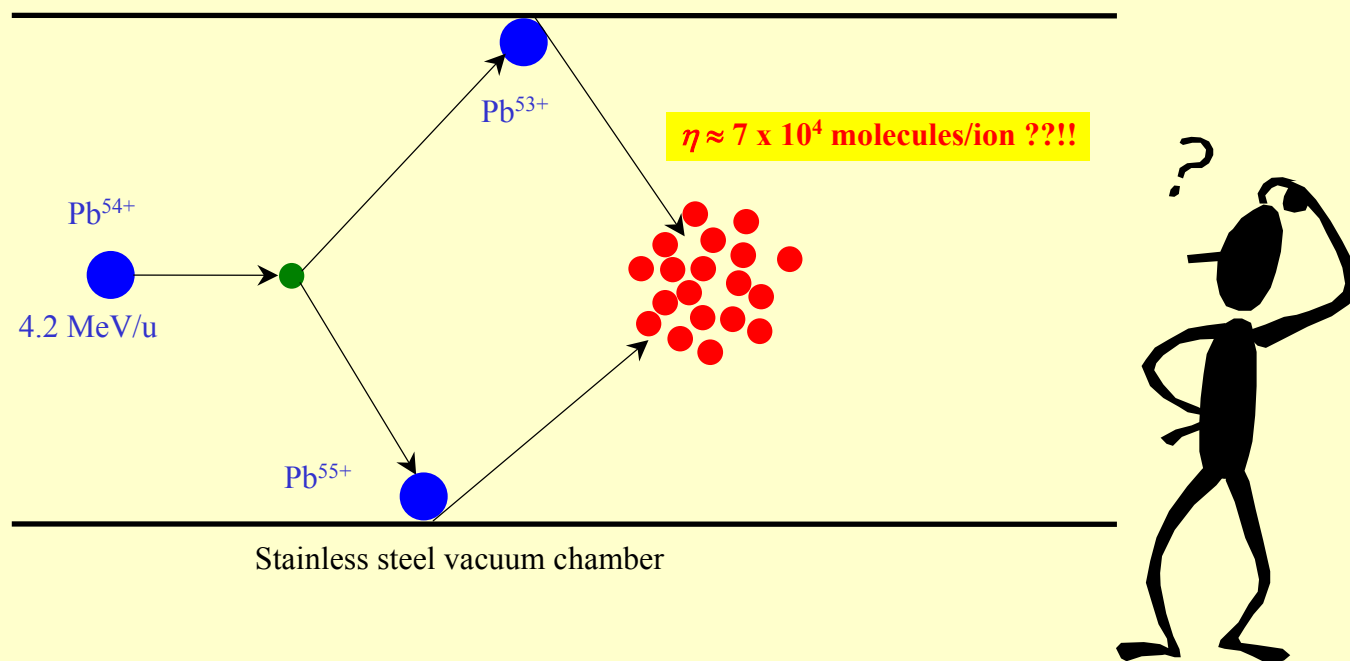
- LEAR static vacuum:  $5 \times 10^{-12}$  Torr
- Dynamic pressure rise up to  $3 \times 10^{-11}$  Torr, not understood
- Outgassing of vacuum equipment due to the impact of lost lead ions ?!

LHC requests:  $9 \times 10^8$  ions,  $\tau = 30$  s



*J. Bosser et al. (1999)*

# Mechanism of beam-loss induced pressure rise in LHC

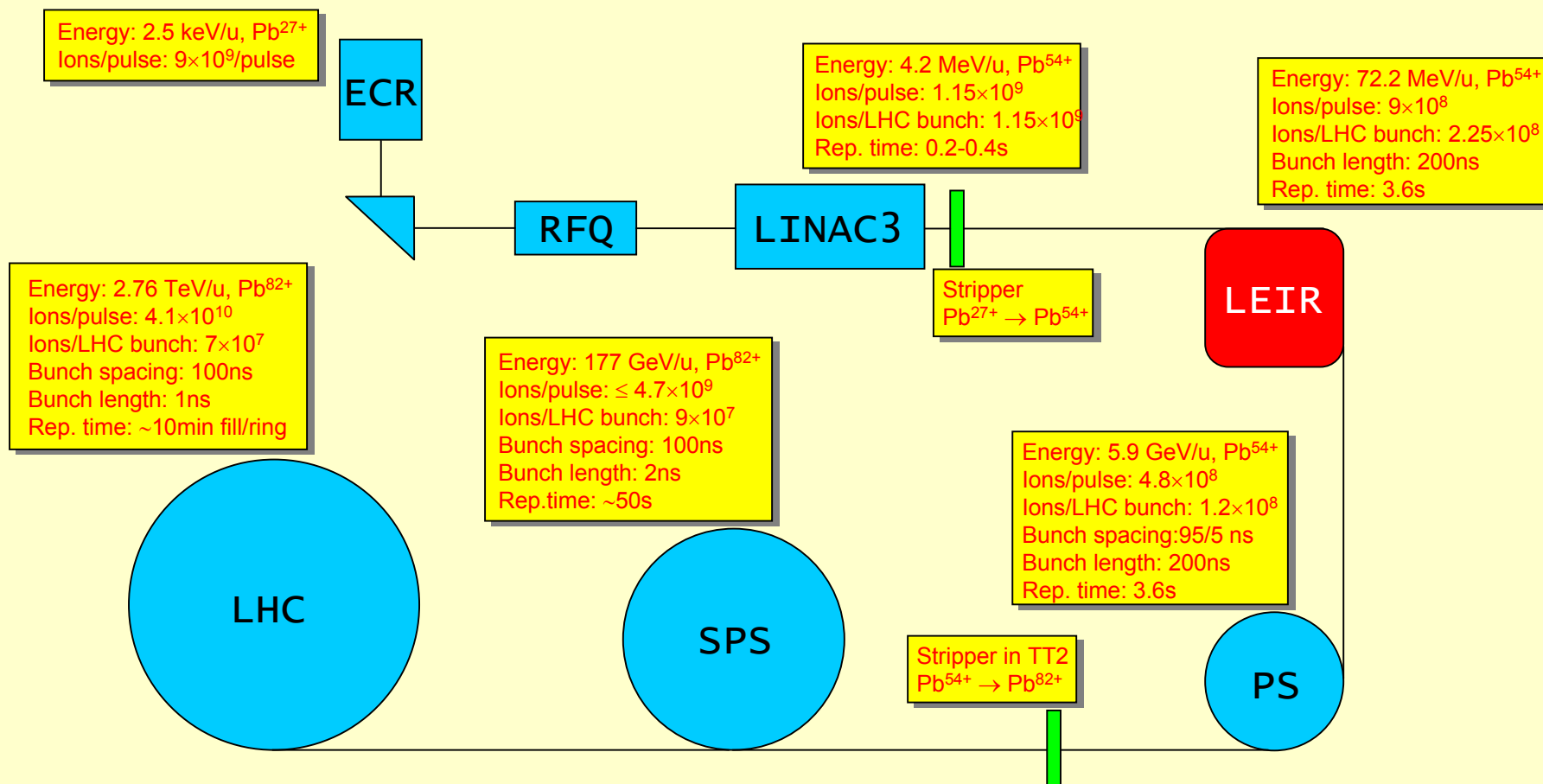






# *LHC requirements for heavy ions*

## *The Pb Injector Chain*





# *LEIR vacuum requirements*

## Basics: lifetime & gas density



- Beam lifetime

$$\frac{1}{\tau} = \beta \times c \times \sigma_{tot} \times n$$

–  $c$ : speed of light,  $n$ : gas density (independent of the gas species)

- Gas density

–  $n \approx 9.656 \times 10^{24} \times p/T$  molec./m<sup>3</sup>

$p$ : pressure (Torr),  $T$ : temperature (Kelvin)

one finds at 20°C, 1 Torr:  $n \approx 3.29 \times 10^{22}$  molec./m<sup>3</sup>

- Gas “mixture”

– replace  $\sigma_{tot} \times n$  by  $\sum \sigma_i \times n_i$

$$\frac{1}{\tau_{total}} = \frac{1}{\tau_{H_2}} + \frac{1}{\tau_{CH_4}} + \frac{1}{\tau_{CO}} + \frac{1}{\tau_{CO_2}} + \dots$$

Cross sections needed  
to calculate the gas density





# Dynamic pressure



- Required dynamic gas densities  $n$  & partial pressures  $P$ 
  - Charge-exchange of a heavy ions, capture & loss of electrons
  - the capture process dominates in LEIR

Gas	Franzke $\tau = 30$ s $n$ [m <sup>-3</sup> ]	Schlachter $\tau = 30$ s $n$ [m <sup>-3</sup> ]	Franzke $\tau = 30$ s $P$ [Torr] @ 20°C	Schlachter $\tau = 30$ s $P$ [Torr] @ 20°C
H <sub>2</sub>	$7.22 \times 10^{+11}$	$2.71 \times 10^{+13}$	$2.20 \times 10^{-11}$	$8.24 \times 10^{-10}$
He	$7.23 \times 10^{+11}$	$2.98 \times 10^{+12}$	$2.20 \times 10^{-11}$	$9.05 \times 10^{-11}$
CH <sub>4</sub>	$1.46 \times 10^{+11}$	$2.30 \times 10^{+11}$	$4.45 \times 10^{-12}$	$6.99 \times 10^{-12}$
H <sub>2</sub> O	$1.49 \times 10^{+11}$	$1.70 \times 10^{+11}$	$4.54 \times 10^{-12}$	$5.17 \times 10^{-12}$
N <sub>2</sub>	$1.06 \times 10^{+11}$	$9.88 \times 10^{+10}$	$3.23 \times 10^{-12}$	$3.01 \times 10^{-12}$
CO	$1.07 \times 10^{+11}$	$9.88 \times 10^{+10}$	$3.24 \times 10^{-12}$	$3.00 \times 10^{-12}$
Ar	$9.50 \times 10^{+10}$	$8.33 \times 10^{+10}$	$2.89 \times 10^{-12}$	$2.53 \times 10^{-12}$
CO <sub>2</sub>	$6.81 \times 10^{+10}$	$6.26 \times 10^{+10}$	$2.07 \times 10^{-12}$	$1.90 \times 10^{-12}$

Total cross sections calculated with Franzke's and Schlachter's formulae

Gas density  $n$  for  $\tau = 30$  s

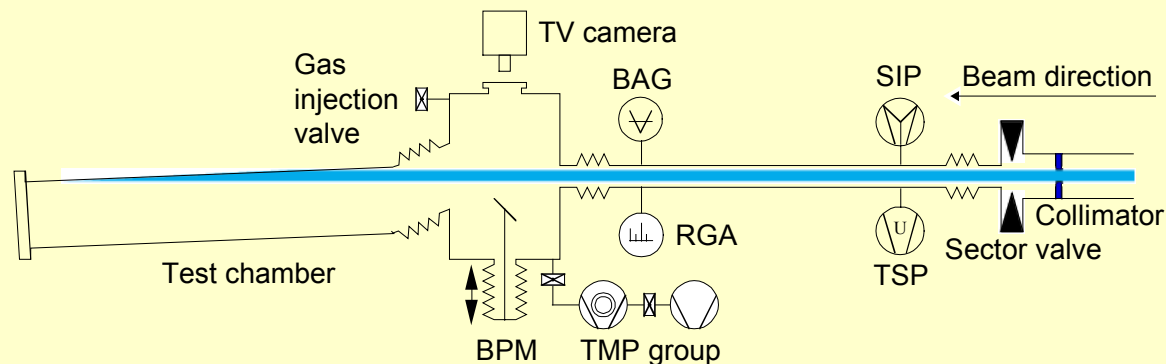
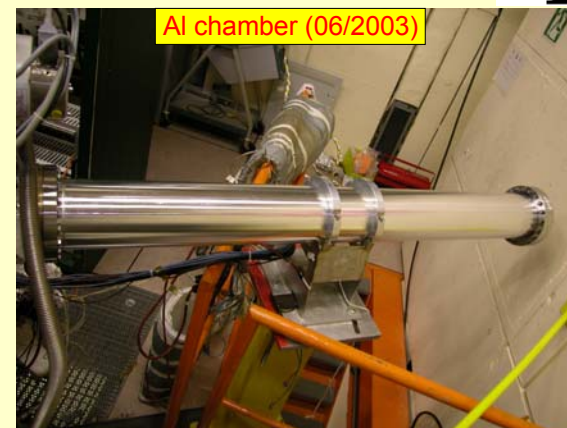
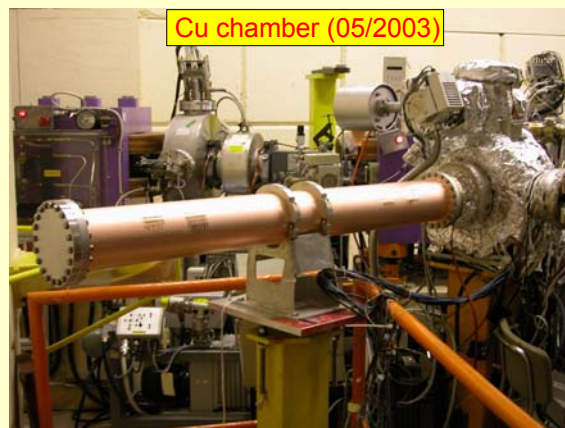
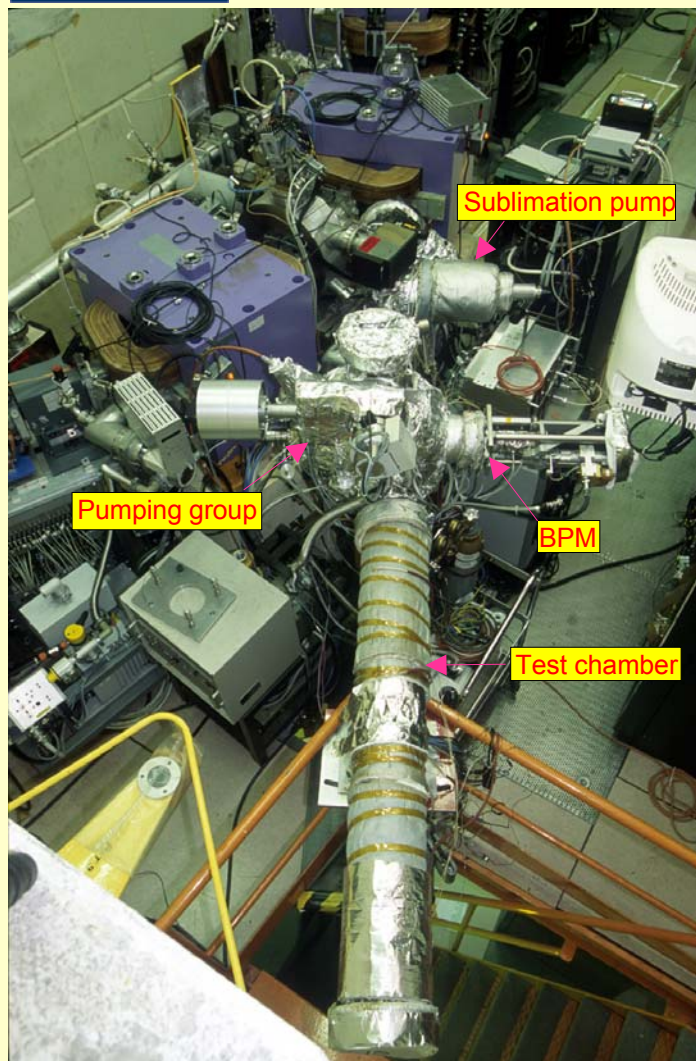
Gas composition

$P_{\text{dynamic}}$  for LEIR

4.2 MeV/u  
Pb<sup>54+</sup>

- Typical gas composition under heavy ion bombardment
  - Results from LINAC 3 desorption experiment:  
CO (72%), CO<sub>2</sub> (18%), CH<sub>4</sub> (7%), H<sub>2</sub> (3%).
- Required average dynamic pressure in LEIR
  - $P_{\text{dynamic}} \approx 3 \times 10^{-12}$  Torr !

# Experimental setup at LINAC 3



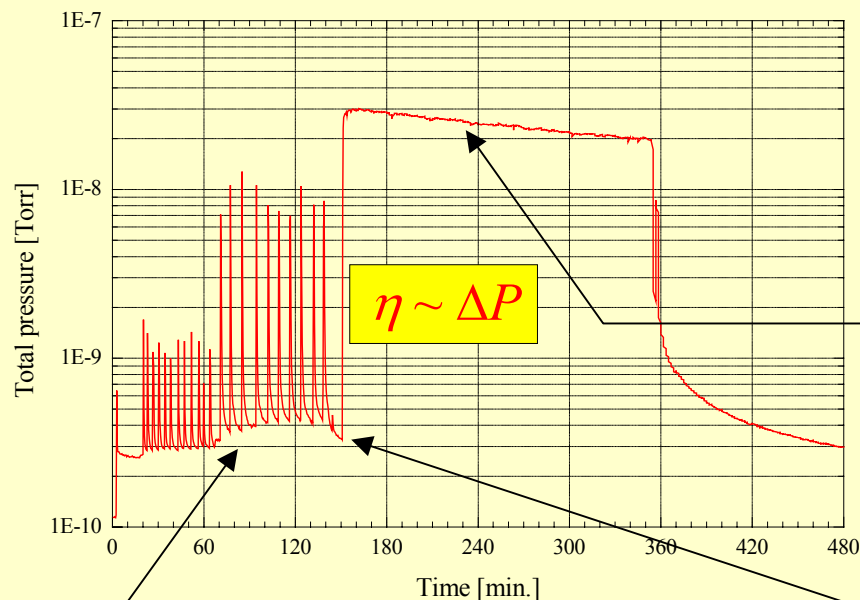
Particles:  $\sim 10^{10}$  Pb<sup>27+</sup> or  $\sim 1.5 \times 10^9$  Pb<sup>53+</sup>

Repetition time: 1.2s

Impact angles studied:  $\theta = 89.2^\circ, 84.8^\circ, 0^\circ$  (perpend.)

# Desorption yield measurements

$\eta$  : desorbed molecules/impacting ion



Single-shots

Continuous injection

$$\eta_{eff,ss} = \frac{\Delta P \times V}{N_{pb} \times k_B \times T} = G \times \frac{\Delta P \times V}{N_{pb}}$$

$$\eta_{eff} = \frac{\Delta P \times S}{\dot{N}_{pb} \times k_B \times T} = G \times \frac{\Delta P \times S}{\dot{N}_{pb}}$$

$\Delta P$ : partial pressure increase,  $V$ : volume,  $S$ : pumping speed

$N_{pb}$ : number of impacting ions,  $\dot{N}_{pb}$ : flux of impacting ions

$k_B$ : Boltzmann constant,  $T$ : temperature

$G: \approx 3.2 \times 10^{19}$  at 300 K, converts (Torr  $\times$   $\ell$ ) into molecules



# *Review of LINAC 3 experiments 2001-2003*



15 vacuum chambers built, 21 different surfaces tested

Results presented for: 4.2 MeV/u,  $\text{Pb}^{53+}$ ,  $\Theta = 89.2^\circ$

## Glow discharges, polishing

As received

Glow discharged: Ar-O<sub>2</sub>, He-O<sub>2</sub>

Chemical polishing: 50  $\mu\text{m}$

Electropolishing: 50  $\mu\text{m}$ , 150  $\mu\text{m}$

## Noble metal coatings

Galvanic coating: Au/Ni/ss (30  $\mu\text{m}$ , 2  $\mu\text{m}$ , ss)

Galvanic coating: Ag/Ni/ss (2  $\mu\text{m}$ , 2  $\mu\text{m}$ , ss)

Sputtering: Pd/ss (0.6  $\mu\text{m}$ , ss)

## Getter materials

Sputtered NEG: TiZrV/ss (2  $\mu\text{m}$ , ss)

Getter strips St707: ZrVFe (70  $\mu\text{m}$ )

## Vacuum firing

Vacuum firing 1050°C ÷ 950 °C

304L (not vac. fired) ÷ 316 LN

316 LN “getter purified”

Bakeout temperature 300°C ÷ 400 °C

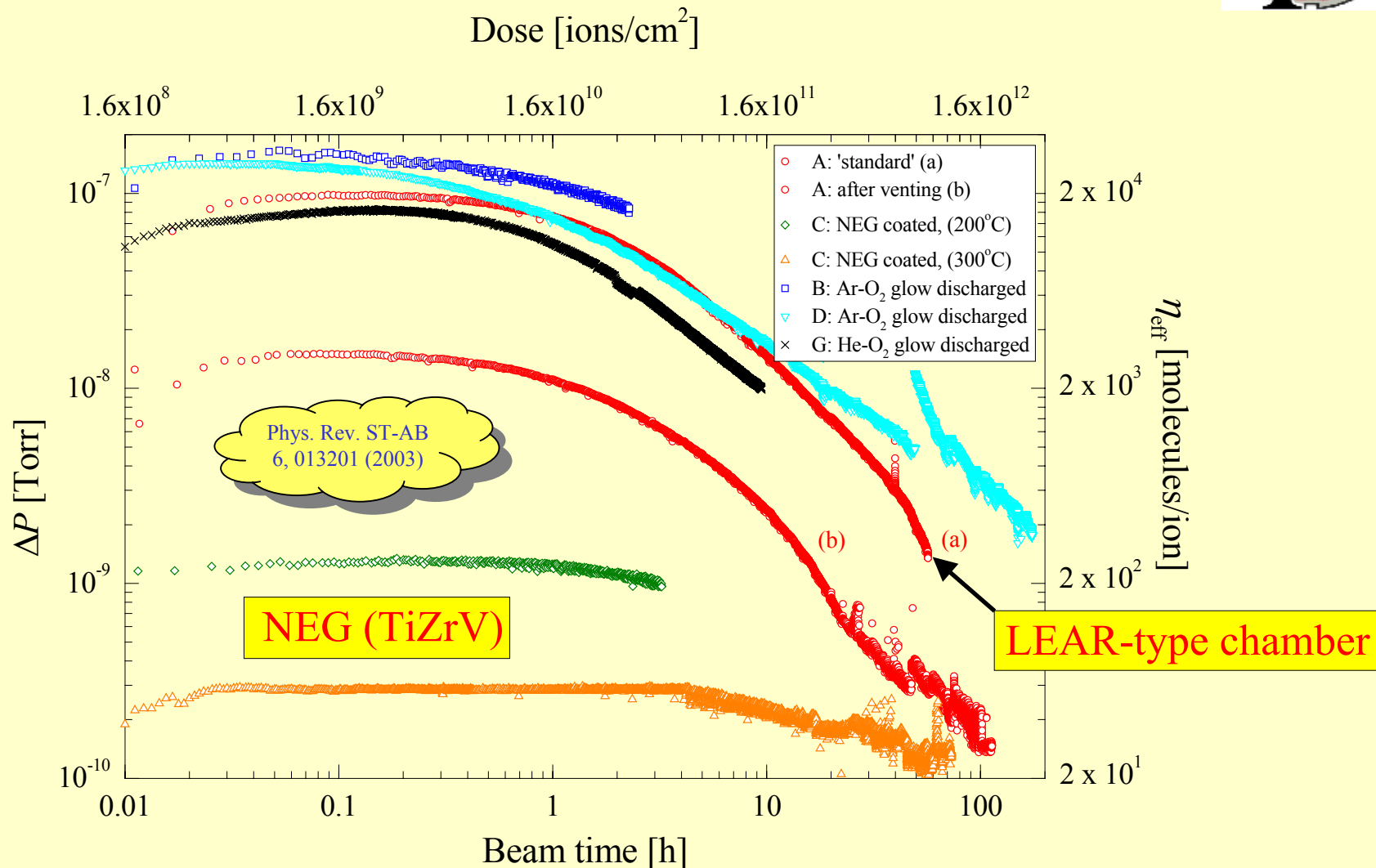
Venting after beam scrubbing

## Other materials Cu, Al, Si, Mo



# LINAC 3 beam scrubbing review (1/8)

'Standard' 316 LN ÷ Ar-O<sub>2</sub> & He-O<sub>2</sub> glow discharges ÷ sputter-coated NEG



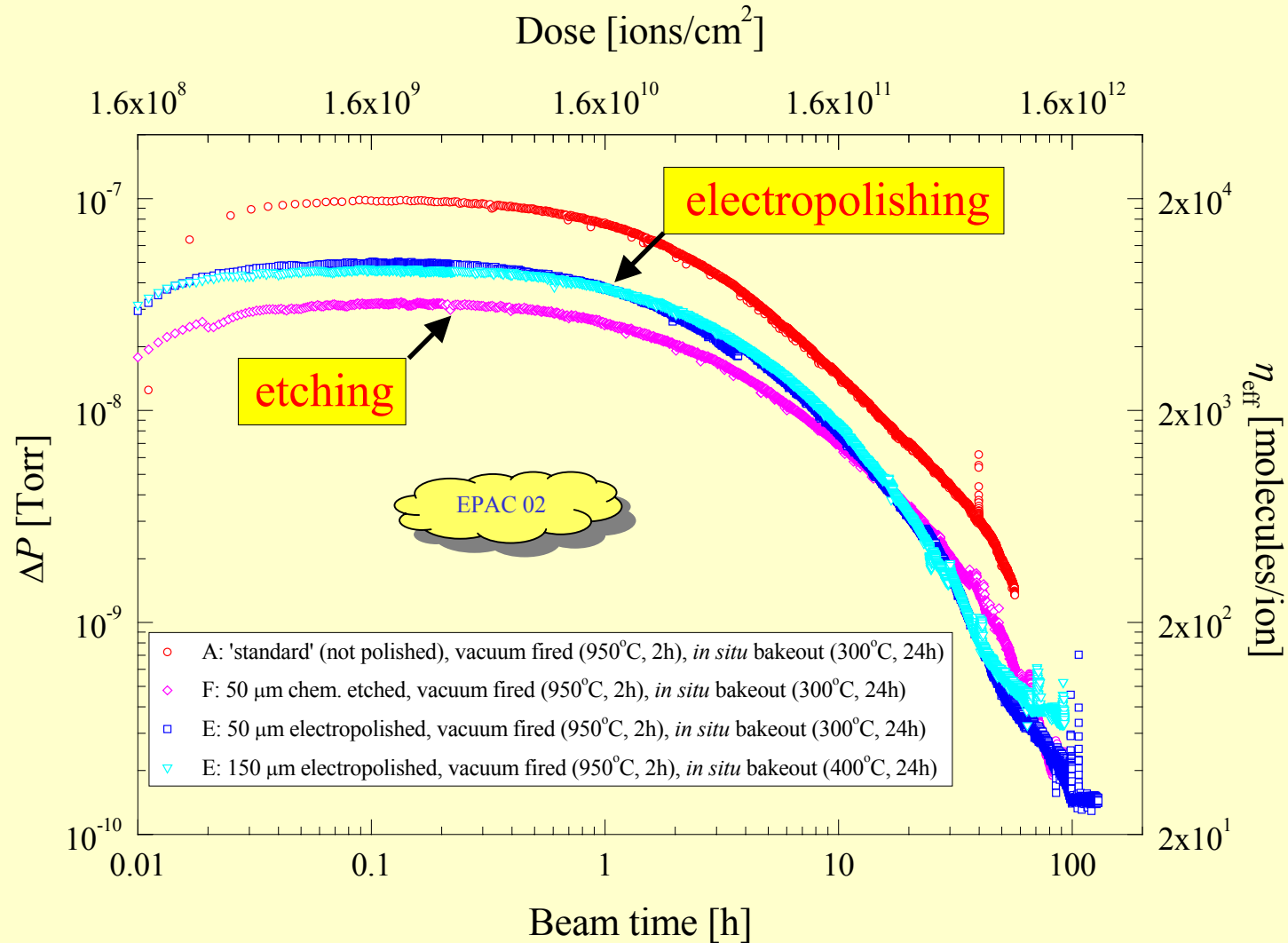




# LINAC 3 beam scrubbing review (2/8)



'Standard' 316 LN ÷ chemical etching ÷ electropolishing

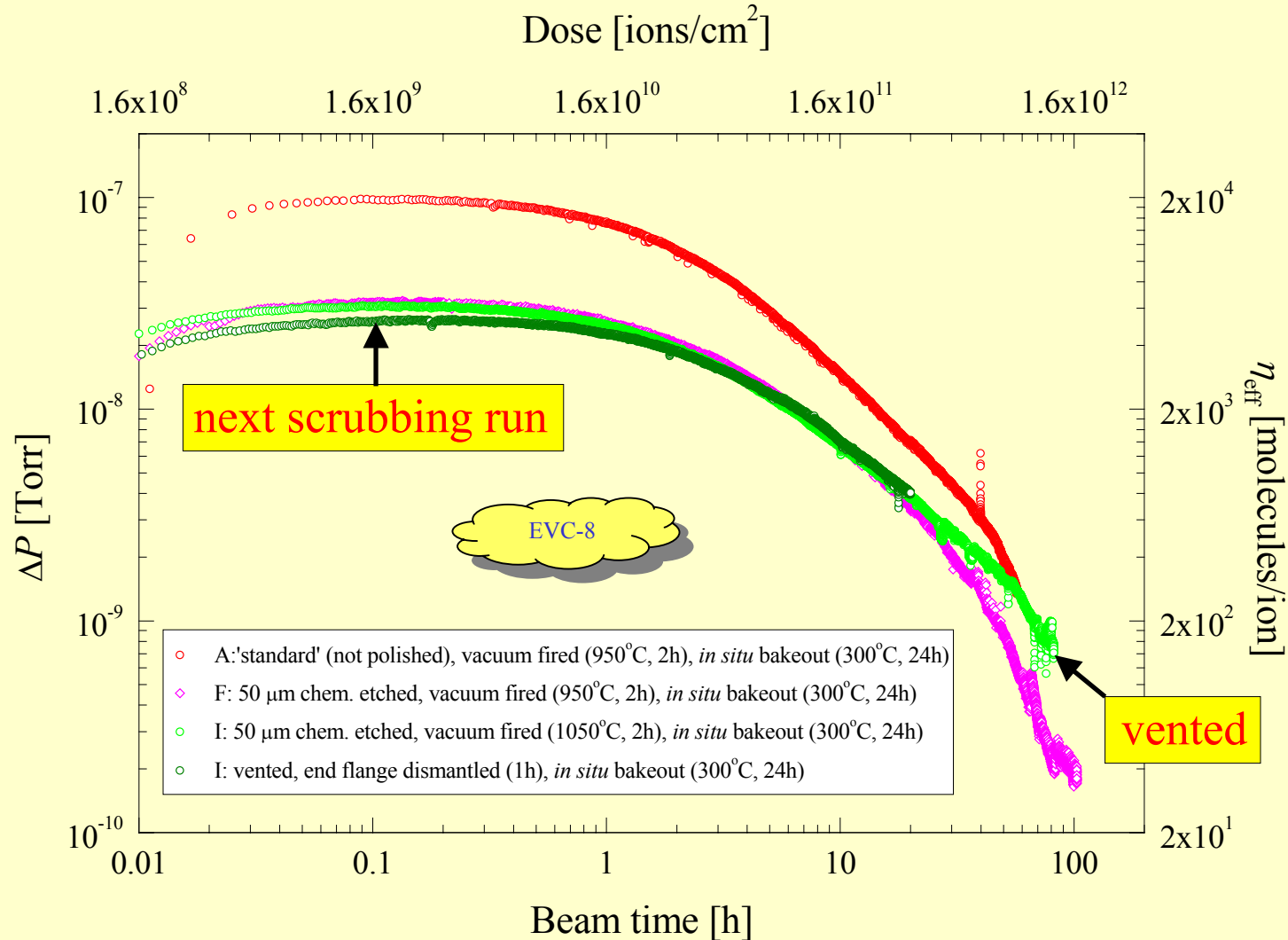


E. Mahner, J. Hansen, D. Kuchler, M. Malabaila, M. Taborrelli



# LINAC 3 beam scrubbing review (3/8)

## Effect of venting after 82h scrubbing



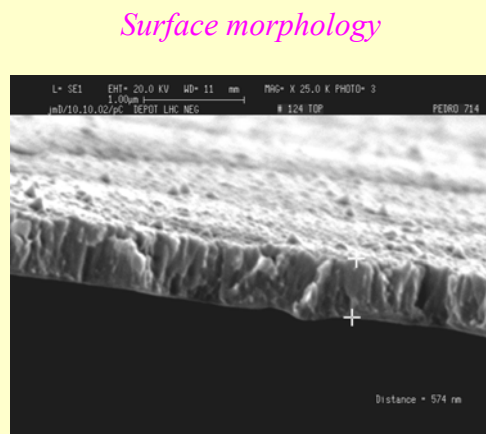
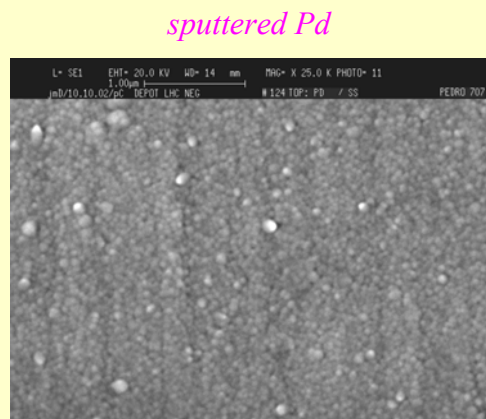
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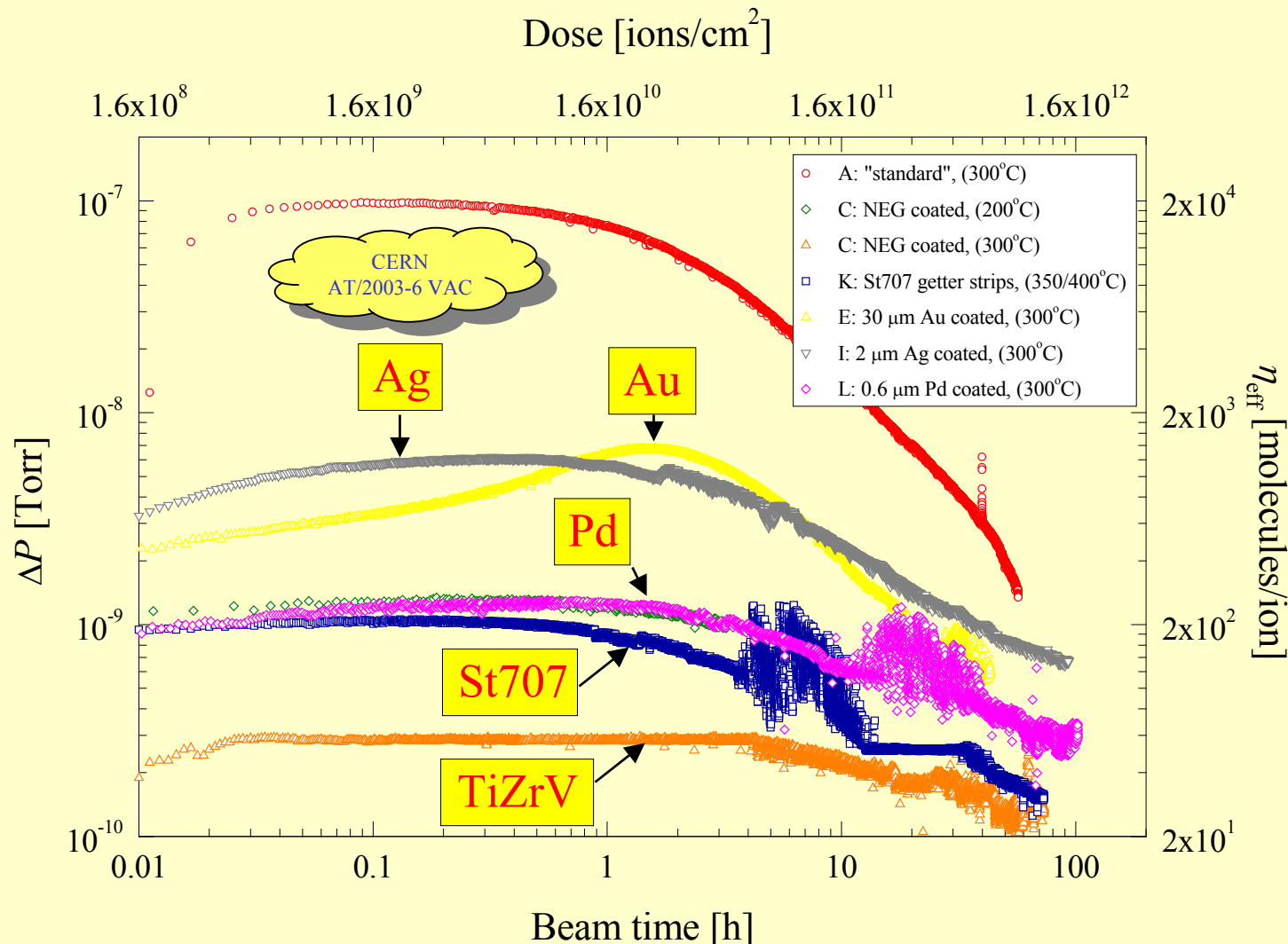
# LINAC 3 beam scrubbing review (4/8)



Au ÷ Ag ÷ Pd films ÷ St707 getter strips ÷ sputter coated NEG



Thickness:  $e = 0.6 \mu\text{m}$





# LINAC 3 beam scrubbing review (5/8)

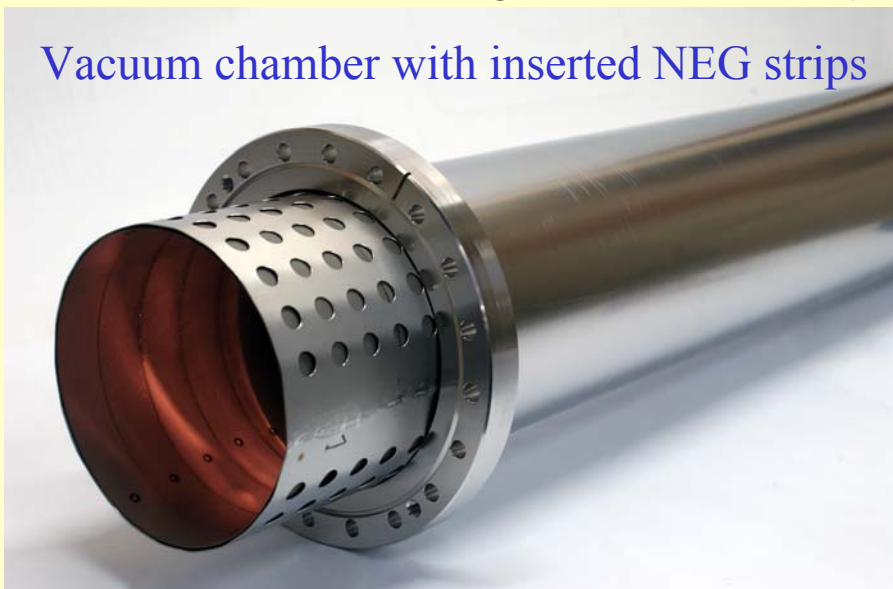
“Total NEG pump” tested at LINAC 3

St707 strips:  $\approx 25$  m total length, 30 mm width

Strips spot welded on 950°C vacuum fired stainless steel cylinders  
*in situ* activation during bakeout: 350°C (24h) + 400°C (3h)



Vacuum chamber with inserted NEG strips

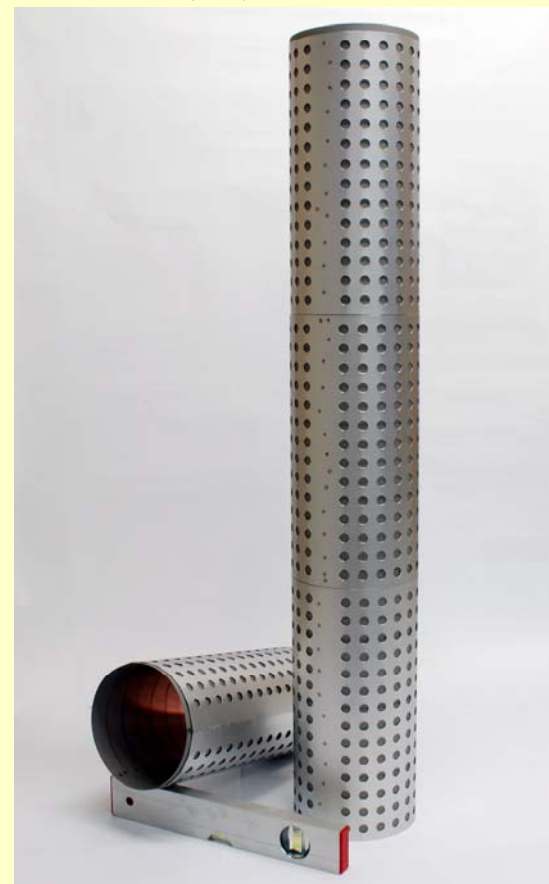


Very large pumping speeds<sup>(\*)</sup>:

$$S_{\text{H}_2}: 1000 \text{ l.s}^{-1}.\text{m}^{-1} \quad S_{\text{CO}}: 2000 \text{ l.s}^{-1}.\text{m}^{-1}$$

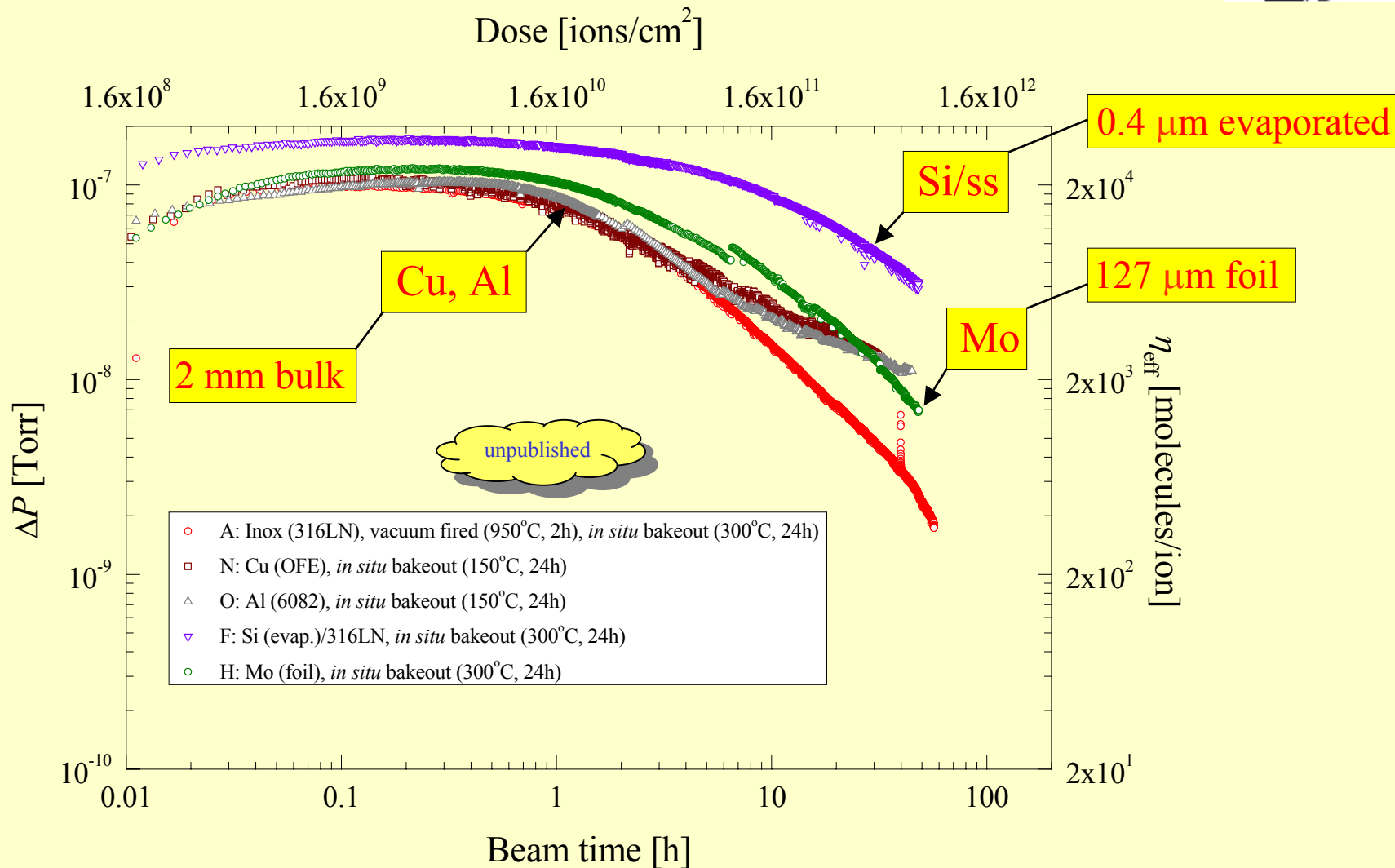
$$S_{\text{CO}_2}: 1500 \text{ l.s}^{-1}.\text{m}^{-1} \quad S_{\text{N}_2}: 450 \text{ l.s}^{-1}.\text{m}^{-1}$$

<sup>(\*)</sup>C. Benvenuti, P. Chiggiato, J. Vac. Sci. Technol. **A14**, 3278 (1996)



# LINAC 3 beam scrubbing review (6/8)

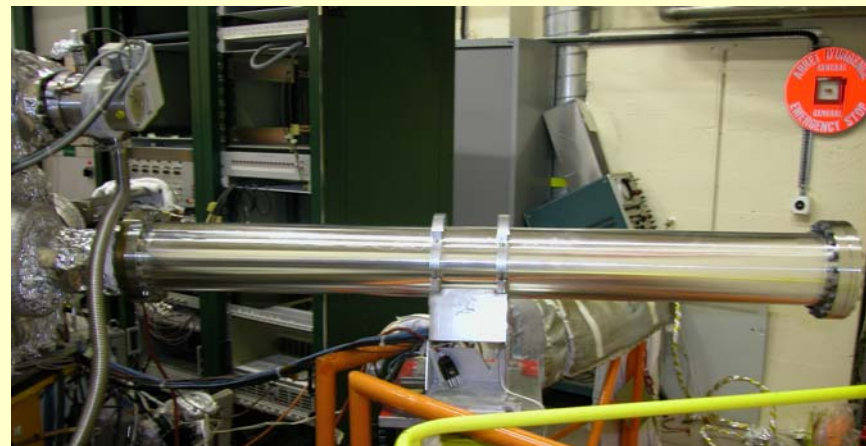
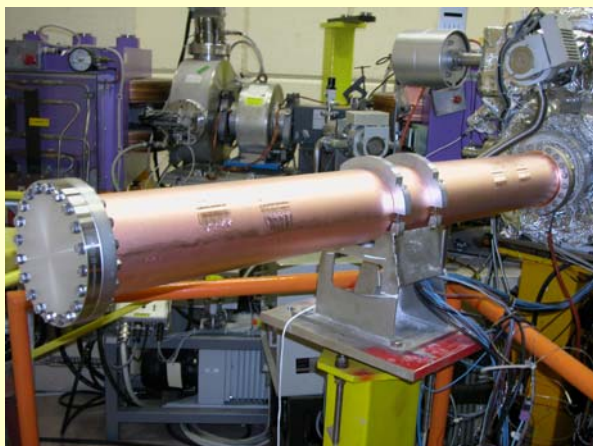
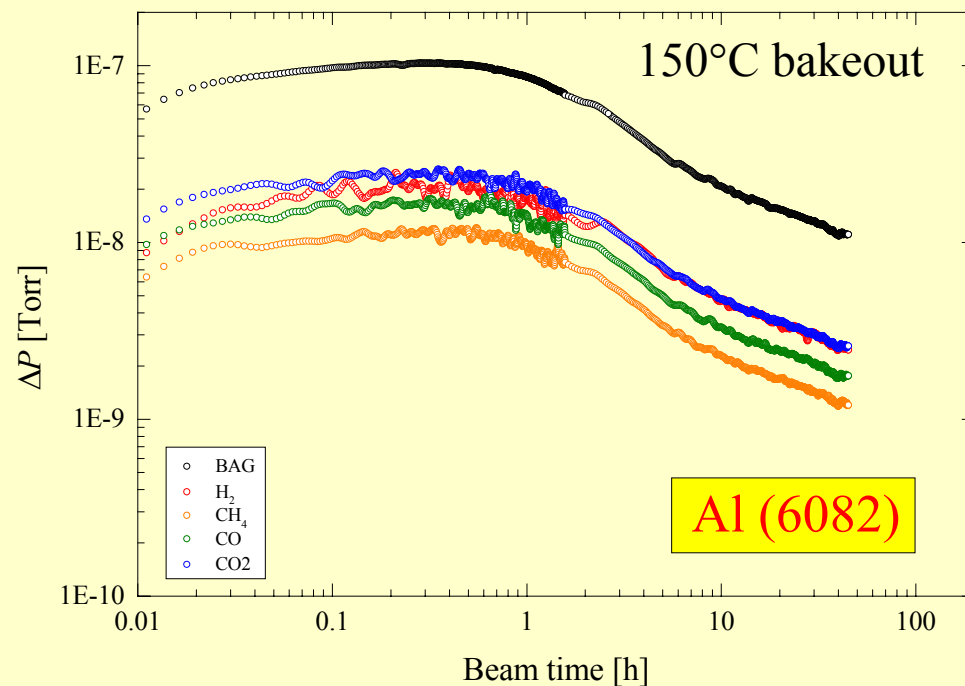
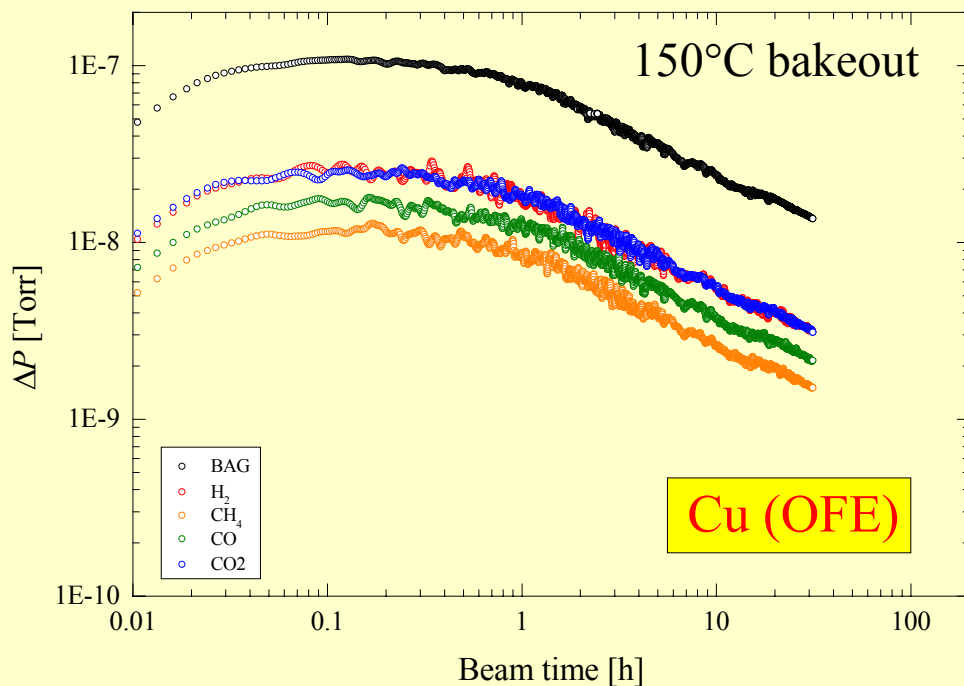
Other materials: Cu, Al, Si/ss, Mo





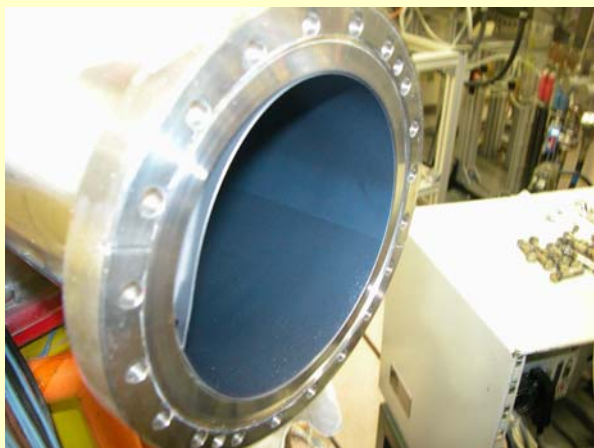
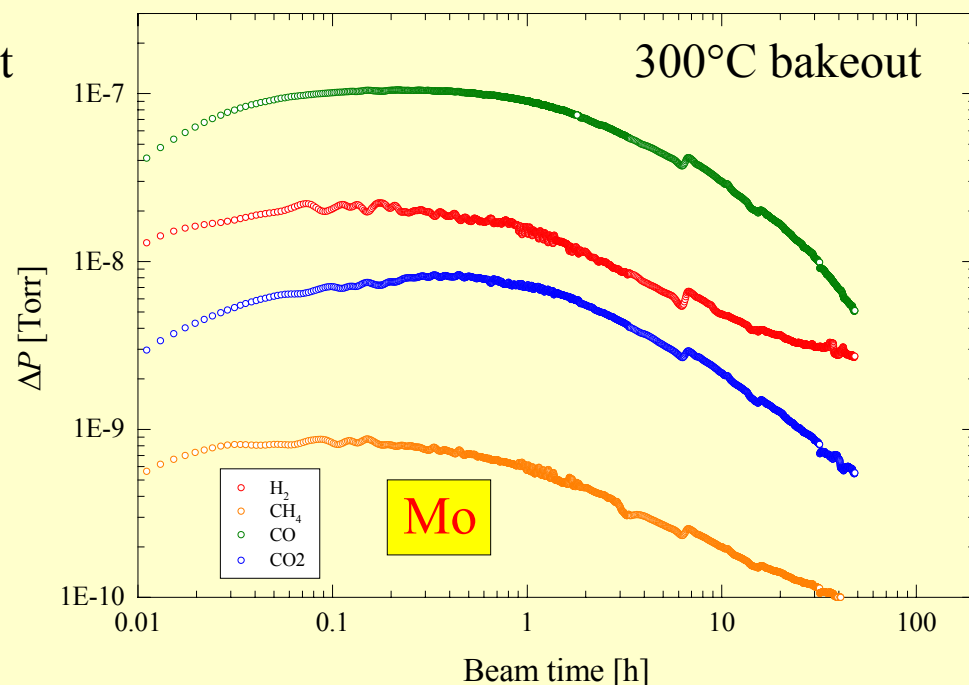
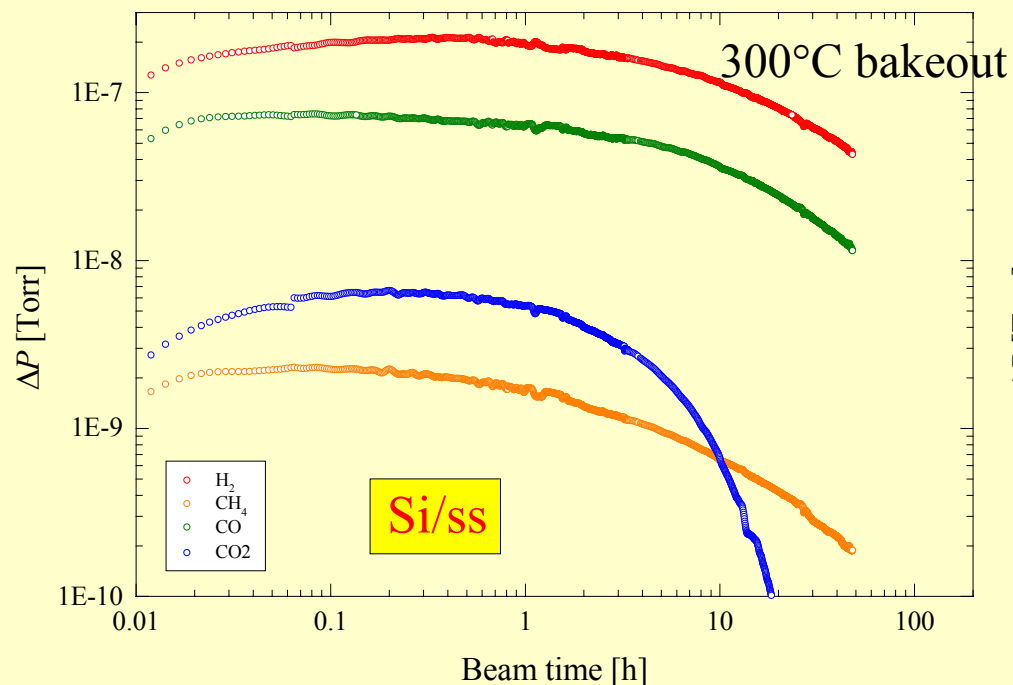
# *LINAC 3 beam scrubbing review (7/8)*

## **Cu & Al: partial pressures**



# LINAC 3 beam scrubbing review (8/8)

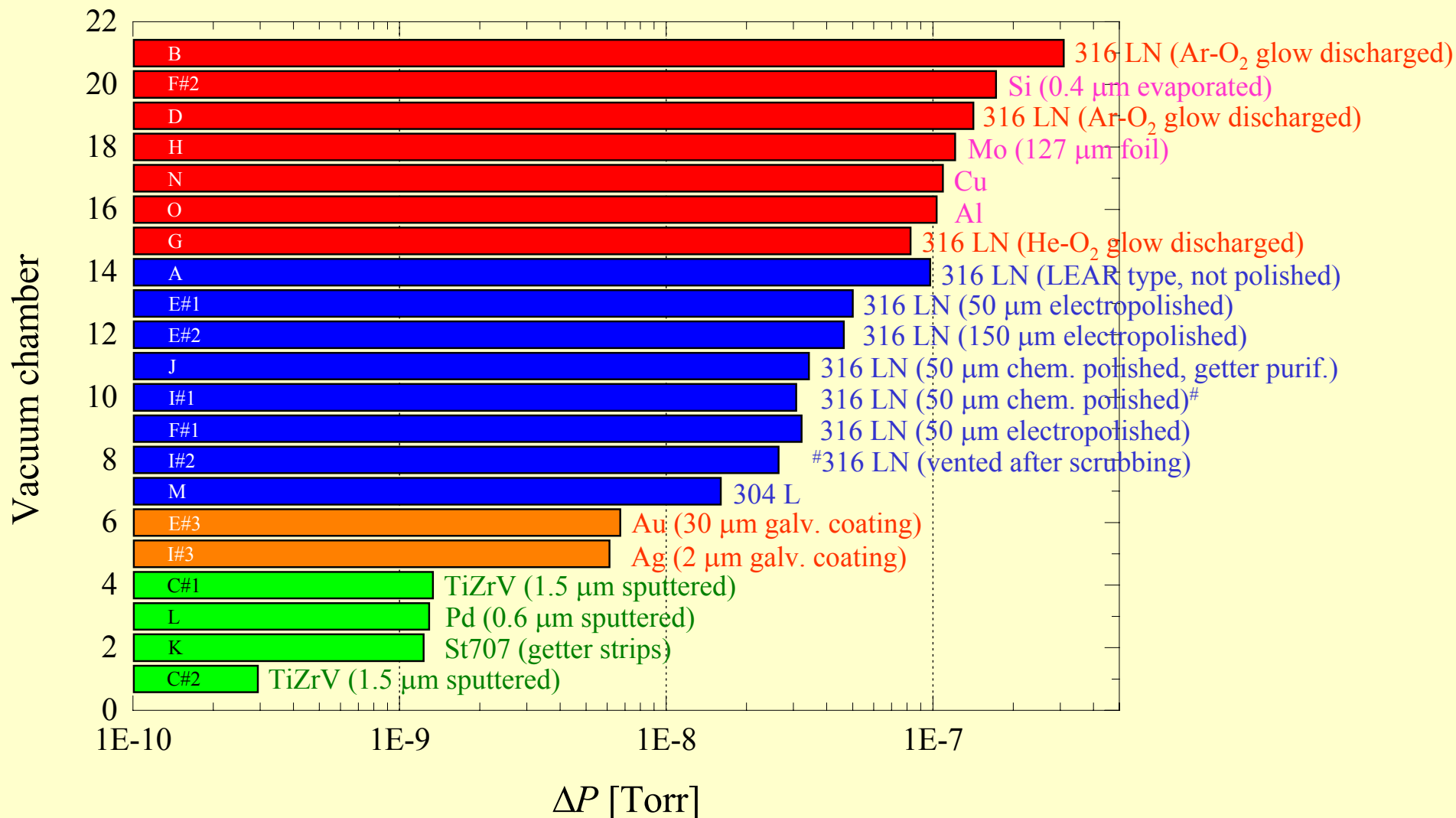
## Si/ss & Mo: partial pressures





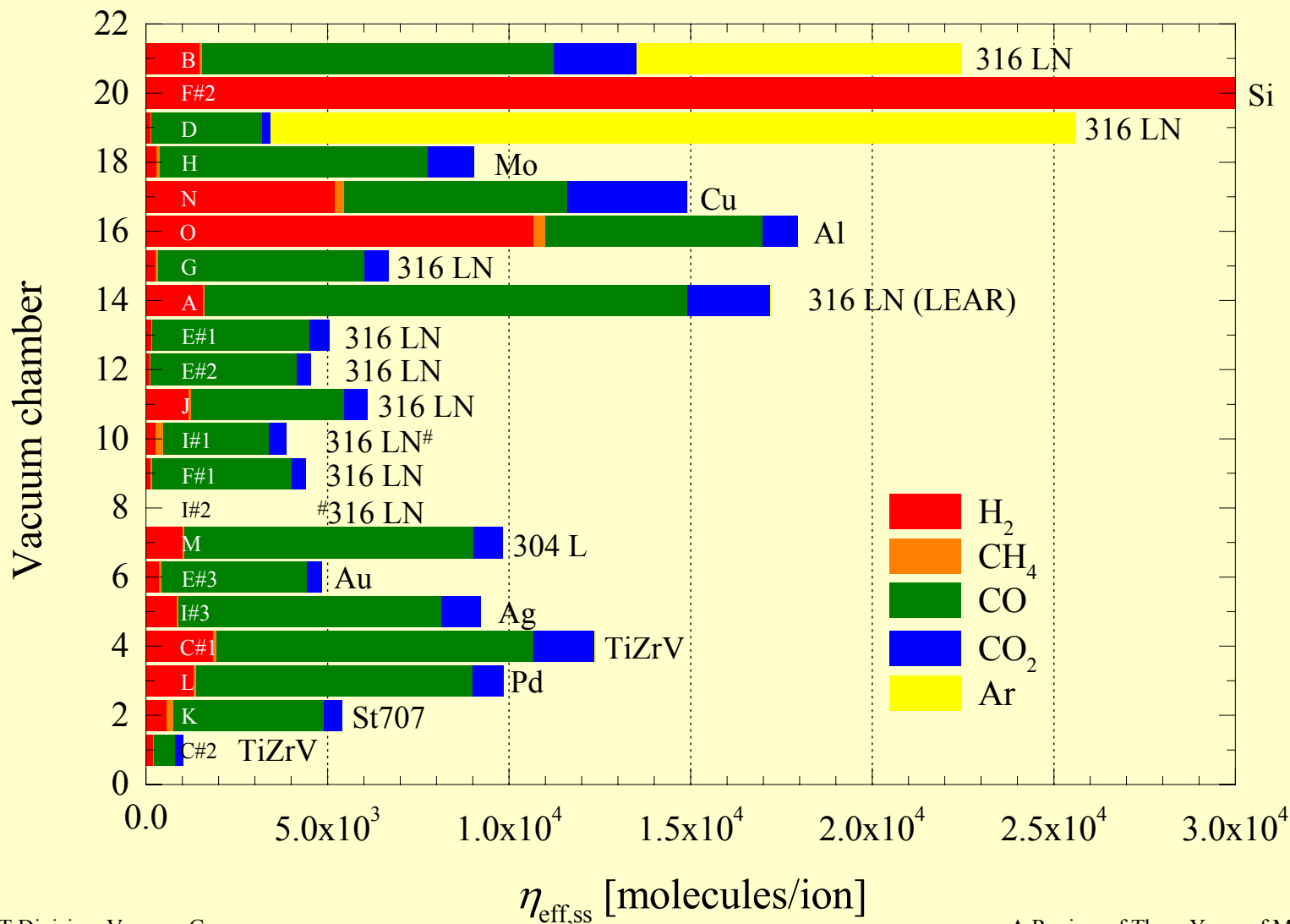
# LINAC 3 review (1/3)

## Pressure rise summary



# LINAC 3 review (2/3)

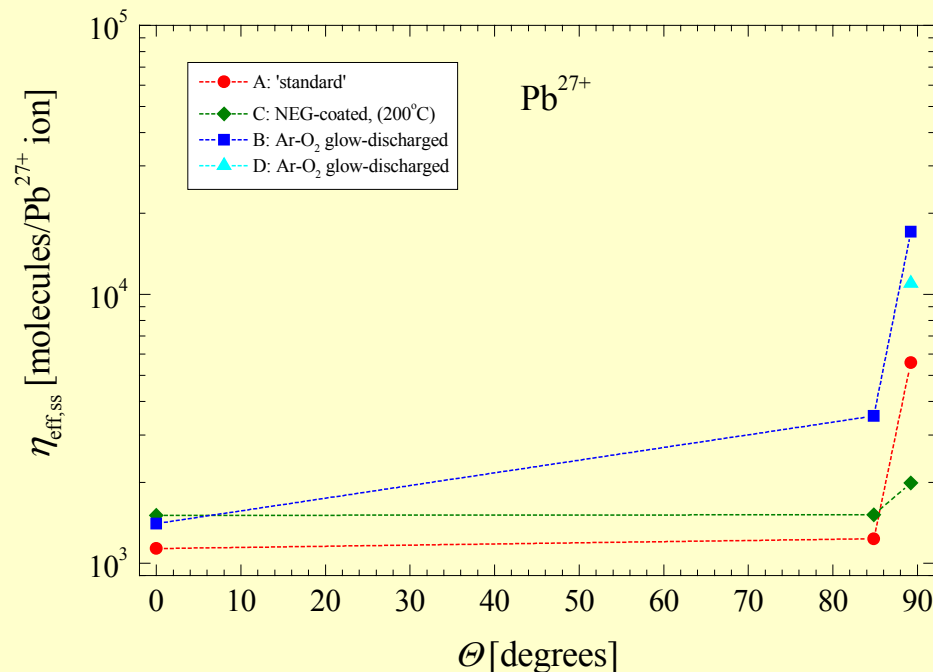
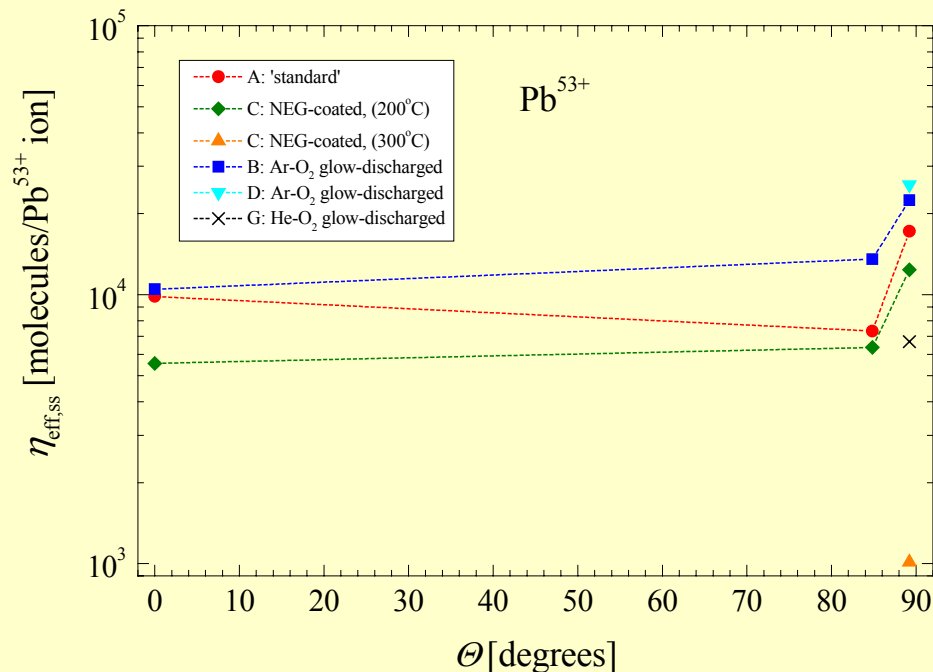
## Partial pressures from single shots





# LINAC 3 review (3/3)

## Impact angle & charge state



- Impact angle (89.2°/perpendicular) for 316 LN stainless steel  
Factor 2 reduced  $\eta$  at  $\theta = 0^\circ \rightarrow$  saw-toothed absorbers
- Ion charge state (53+/27+) for 316 LN stainless steel  
Factor 10 reduced  $\eta$  at  $\theta = 0^\circ \rightarrow$  no impact for LEIR



# Conclusions from LINAC 3 studies



- Origin of LEAR vacuum degradation is understood
  - Measured ( $2 \times 10^4$ ) and calculated ( $7 \times 10^4$ ) desorption yields are in reasonable agreement
  - High dynamic gas loads can be reduced by scrubbing
- Stainless steel surface treatments & coatings
  - Electropolishing or chemical etching slightly reduces  $\eta$
  - Sputter coatings (NEG, Pd) and galvanic coatings strongly reduce the  $\eta$
  - Improvement factors  $\alpha_i$  ( $\equiv$  reduced pressure rise compared to standard 316LN chamber):  
 $\alpha_{\text{epolish}} \approx 2$ ,  $\alpha_{\text{etch}} \approx 3$ ,  $\alpha_{\text{Au}} \approx 15$ ,  $\alpha_{\text{Ag}} \approx 16$ ,  
 $\alpha_{\text{Pd}} \approx 76$ ,  $\alpha_{\text{TiZrV}(200^\circ\text{C})} \approx 72$ ,  $\alpha_{\text{TiZrV}(300^\circ\text{C})} \approx 333$ .
- No influence found on the following parameters
  - Vacuum firing at  $950^\circ\text{C}$  or  $1050^\circ\text{C}$ , *in situ* bakeout at  $300^\circ\text{C}$  or  $400^\circ\text{C}$
  - Thickness of the noble-metal coatings: Au ( $30 \mu\text{m}$ ), Ag ( $2 \mu\text{m}$ ), Pd ( $0.6 \mu\text{m}$ )
- What is not (or only partly) studied !
  - Dependence on: **Energy**, charge state, ion type, temperature... (**SPS desorption experiment**)
  - Contribution of electrons ? Best choice of materials ? Surface or bulk effect ?
  - Is ion-induced track formation an issue for the pressure rise? (probably not)

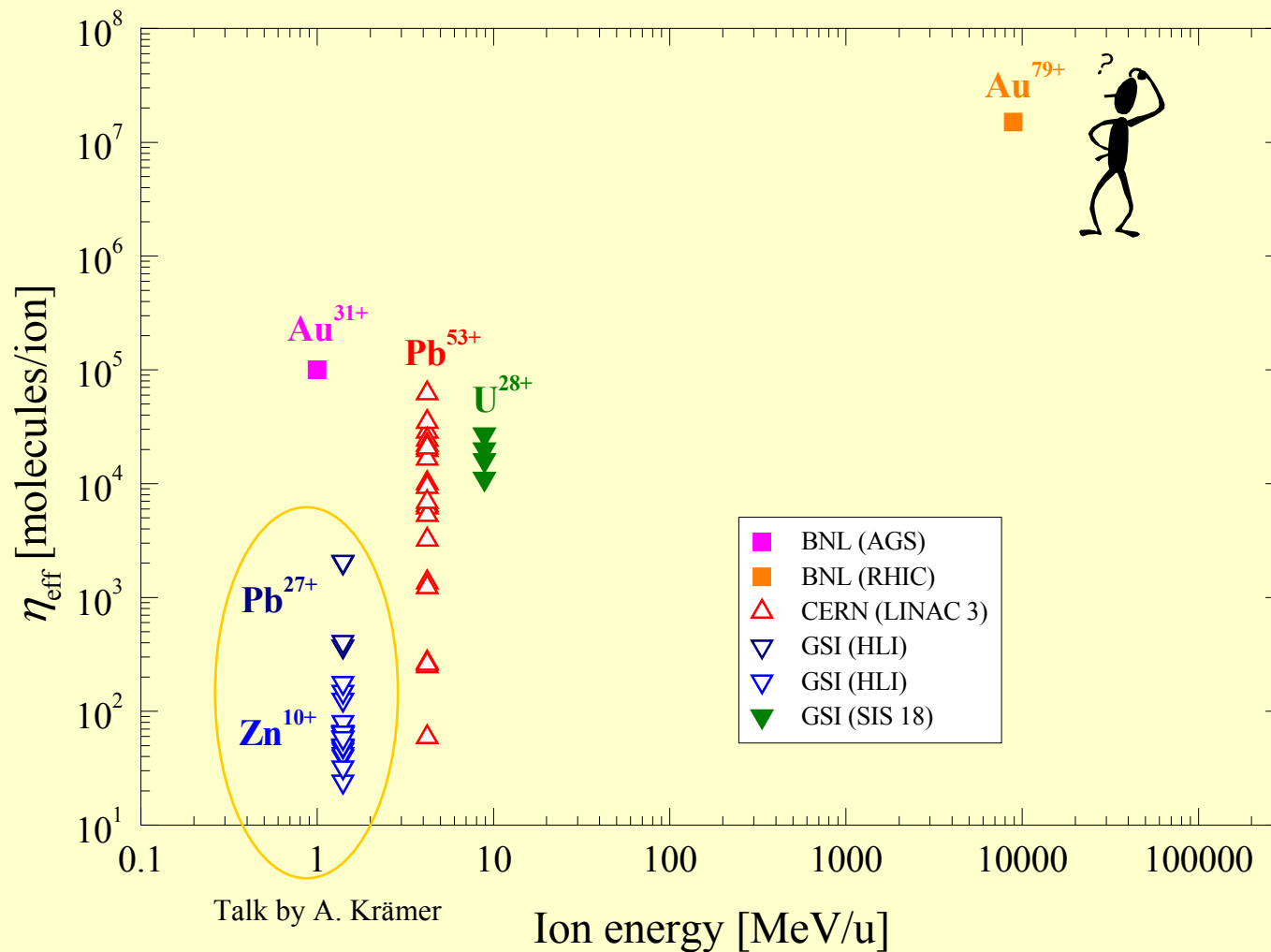


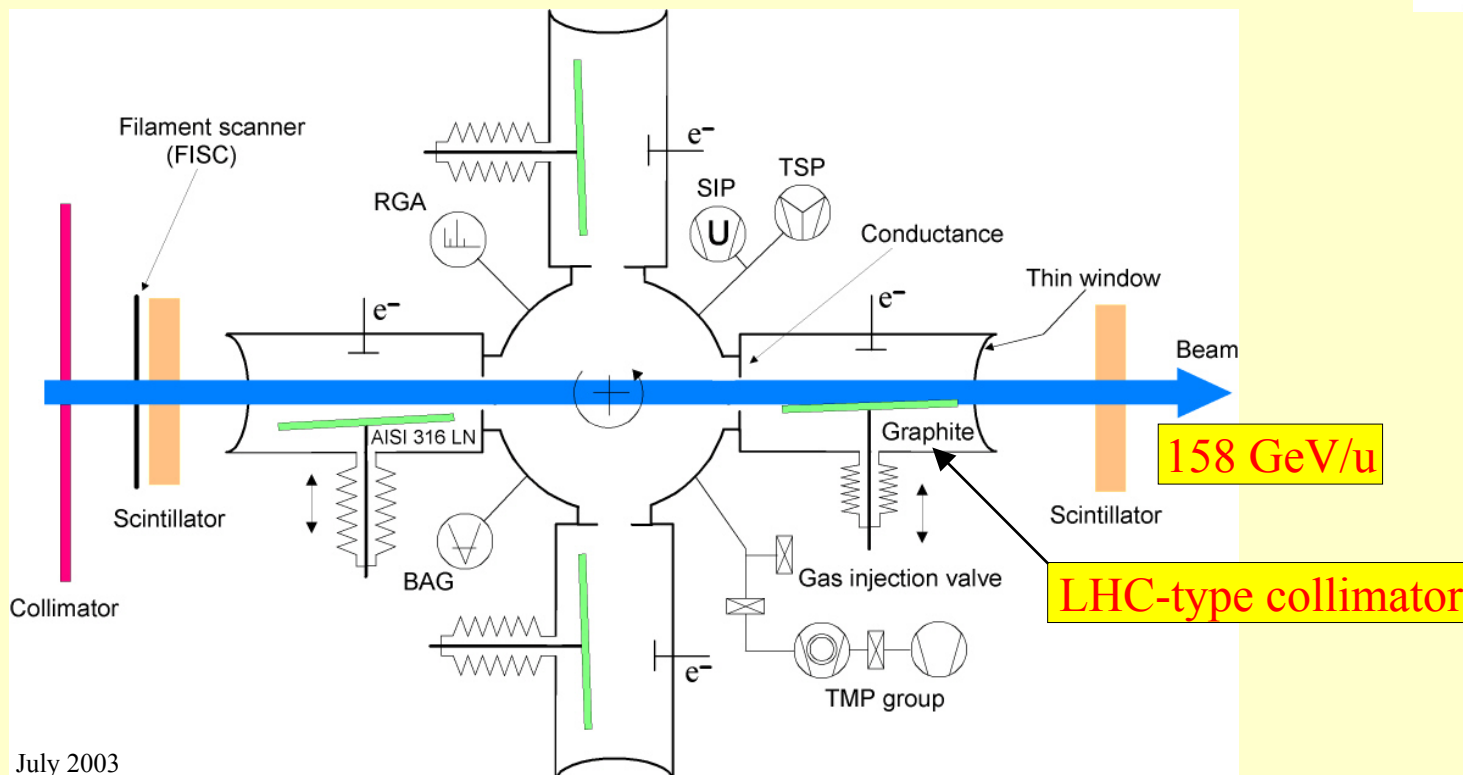
# Consequences for the LEIR vacuum system



- Beam scrubbing
  - Possibility is now demonstrated for Pb ions at 4.2 MeV/u
  - Factor 10 improvement of the dynamic pressure should be feasible
  - Recover as much as possible LEAR vacuum equipment and rely on scrubbing
  - But: scrubbing is lost after venting a sector !
- Installation of (low cost) absorbers to reduce LEIR scrubbing time
  - Absorbers: saw-toothed 316LN sheets coated with: TiZrV, Pd, Au, Ag
  - Positioned at locations where increased ion losses are expected
- NEG coating of all LEIR vacuum chambers
  - NEG coating (wherever possible) to get:
    - Very clean surfaces after *in situ* bakeout
    - Low dynamic gas load under heavy ion impact

# Heavy-ion induced desorption data: Overview





- ⇒ Accelerator: SPS North Area (T4-H8)
  - ⇒ Beam & Energy:  $^{115}\text{In}^{49+}$  at 158 GeV/u
  - ⇒ Intensity:  $1.5 \times 10^6$  ions/spill
  - ⇒ Beam size:  $\leq 5 \times 5 \text{ mm}^2$
  - ⇒ Impact angle: 35 mrad
- A Review



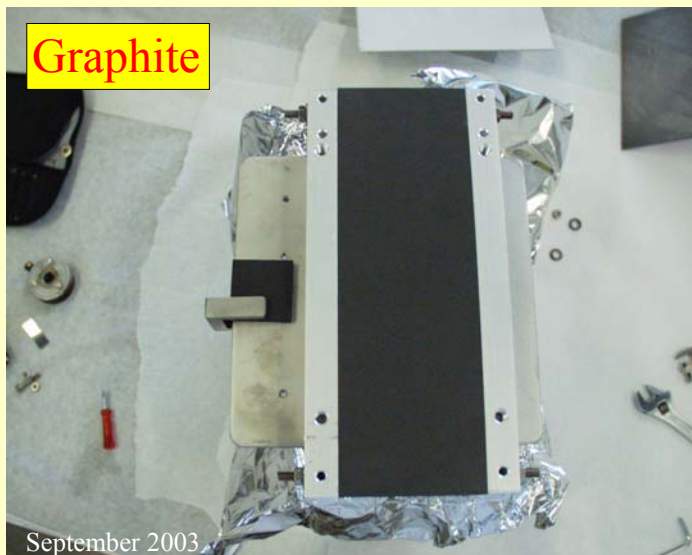


# Graphite collimator coatings with $TiZrV$ and Cu

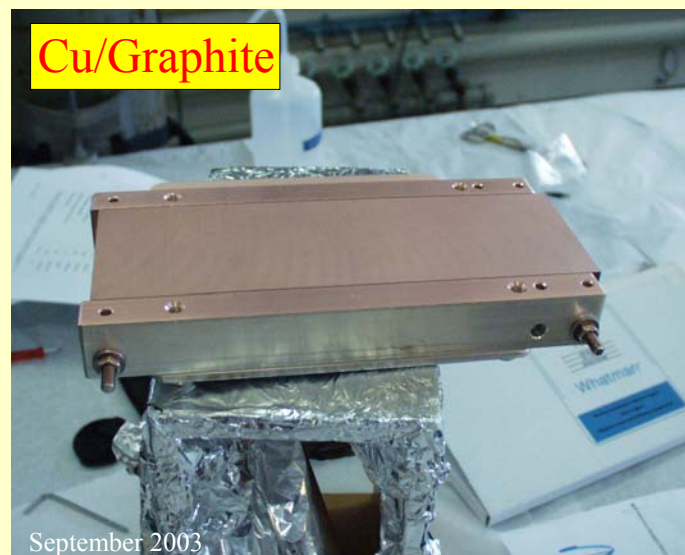
EST/SM: S. Calatroni, W. Vollenberg



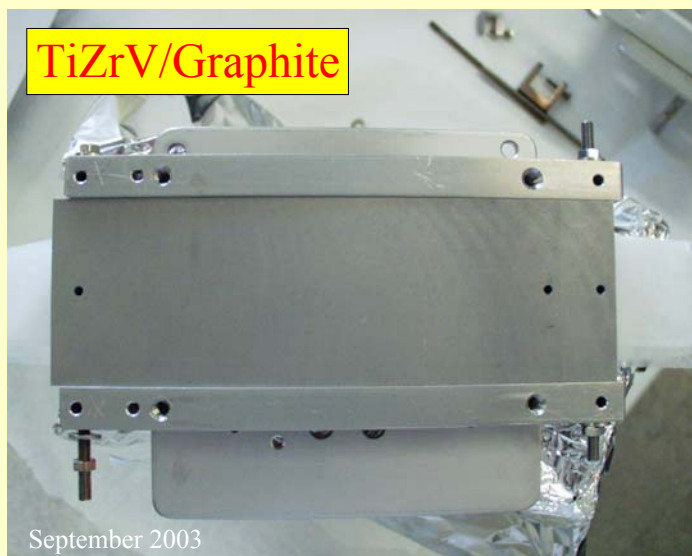
Graphite



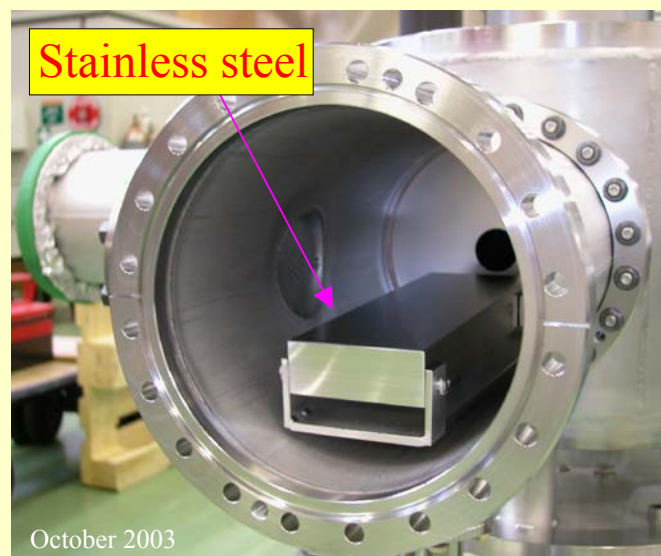
Cu/Graphite



$TiZrV$ /Graphite

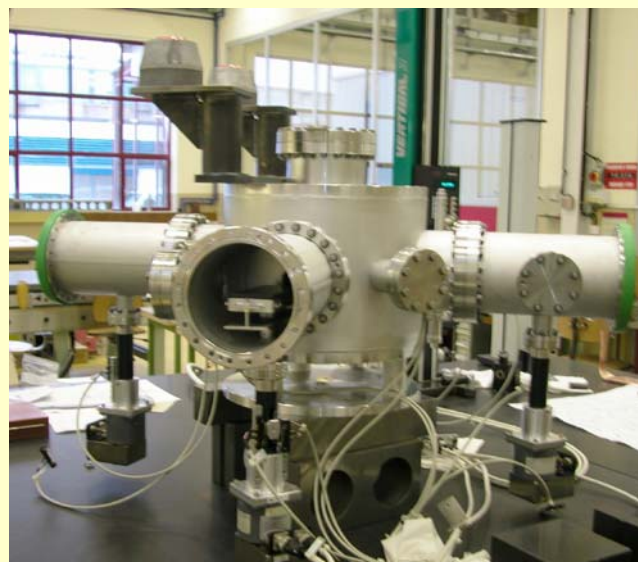


Stainless steel



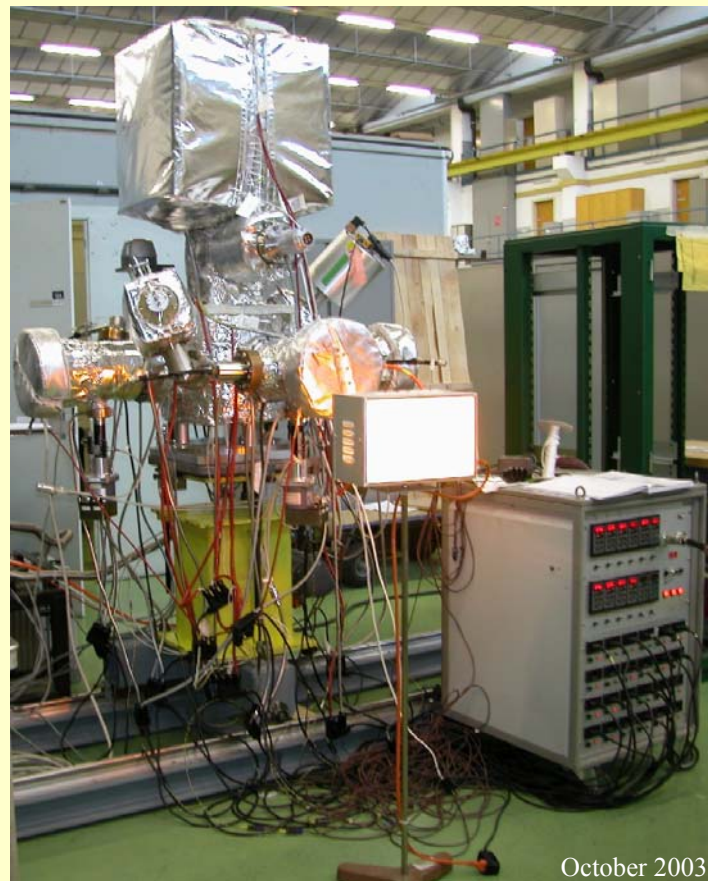


# *Collimator alignment in CERN main workshop*





# *Laboratory installation + first bakeout at 300 °C*



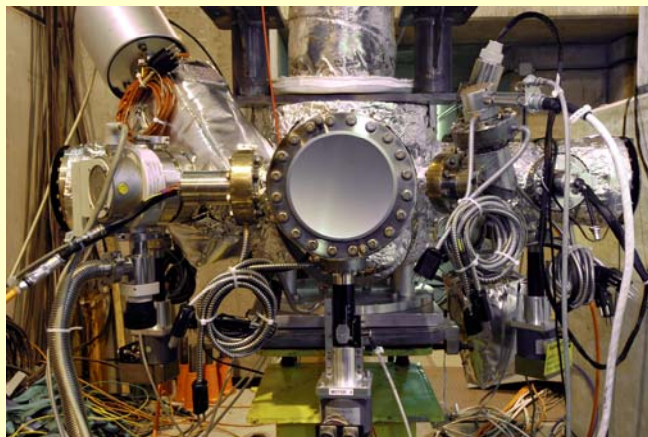
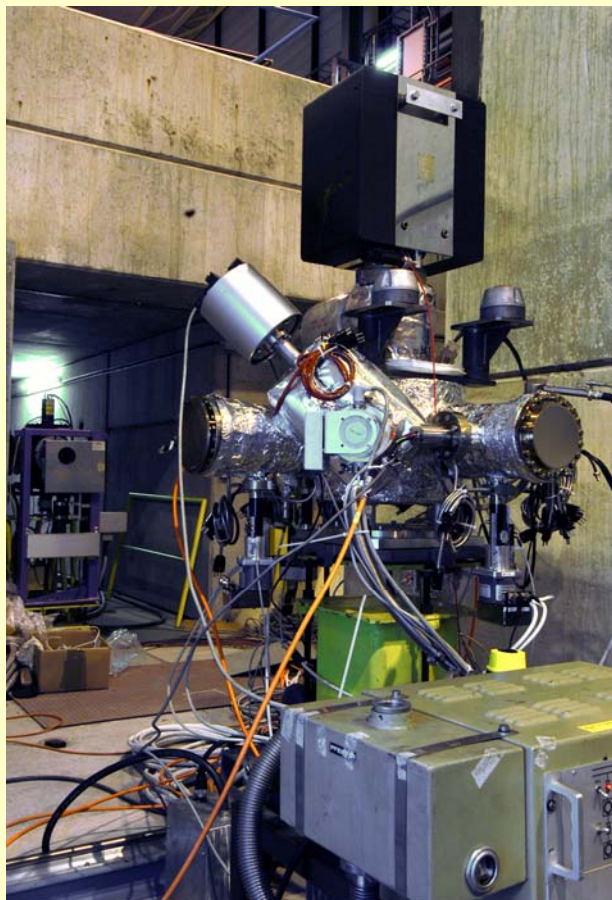
Limit pressure 72h after 1<sup>st</sup> bakeout

$$P \approx 7 \times 10^{-12} \text{ Torr}$$

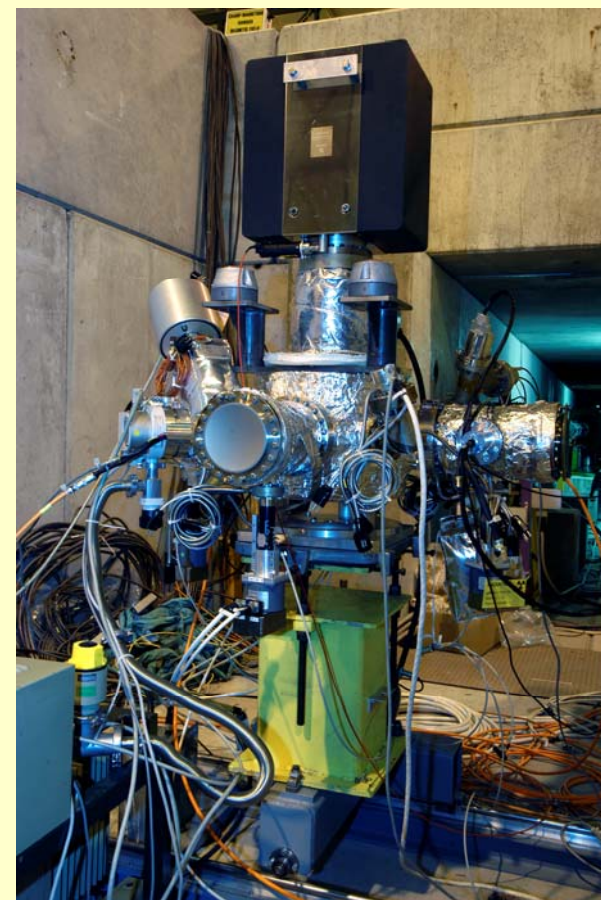




# *Experimental setup installed in the SPS North Area*



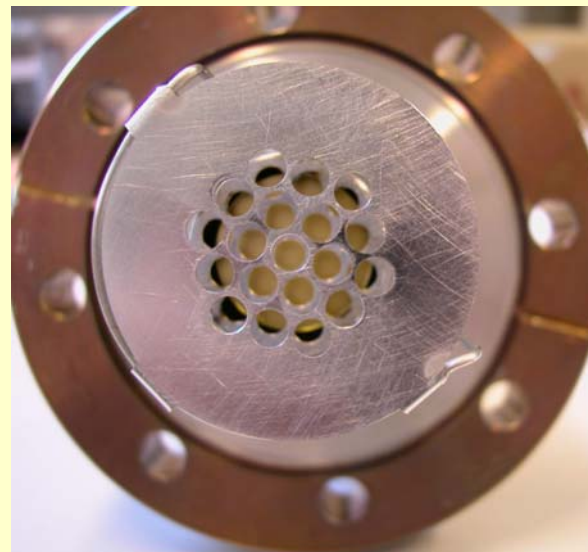
**31. October 2003: Ready for beam !**







# *Electron detectors installed in SPS desorption experiment*



E. Page, J.-M. Laurent







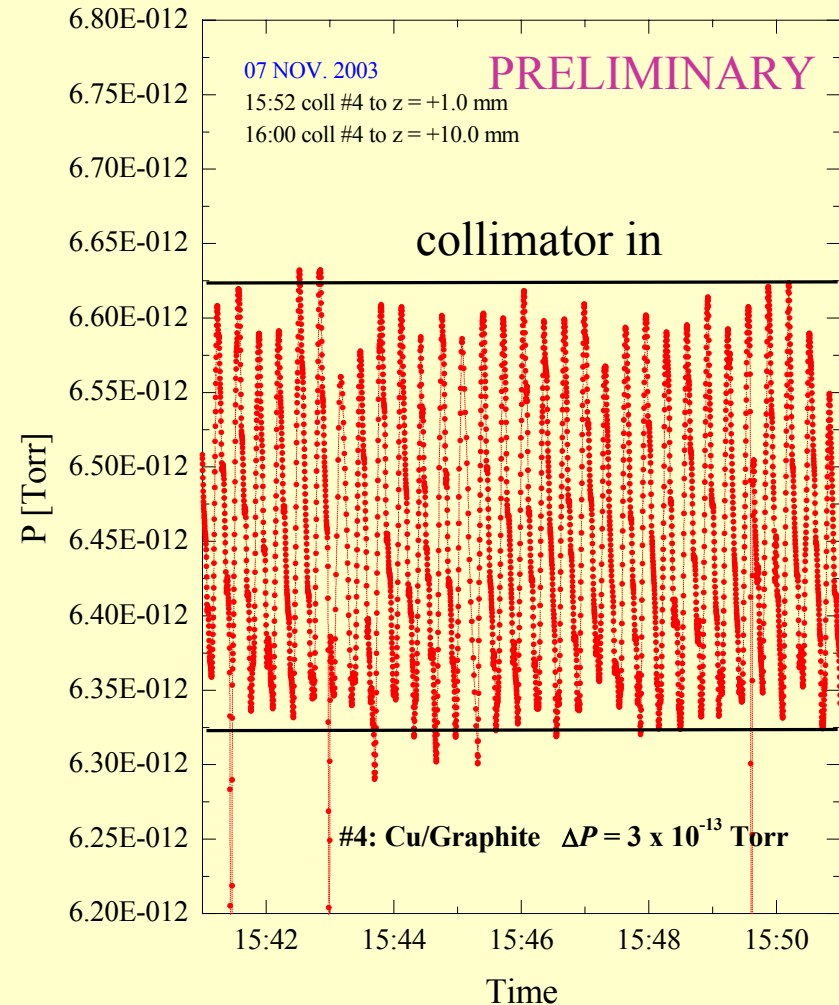
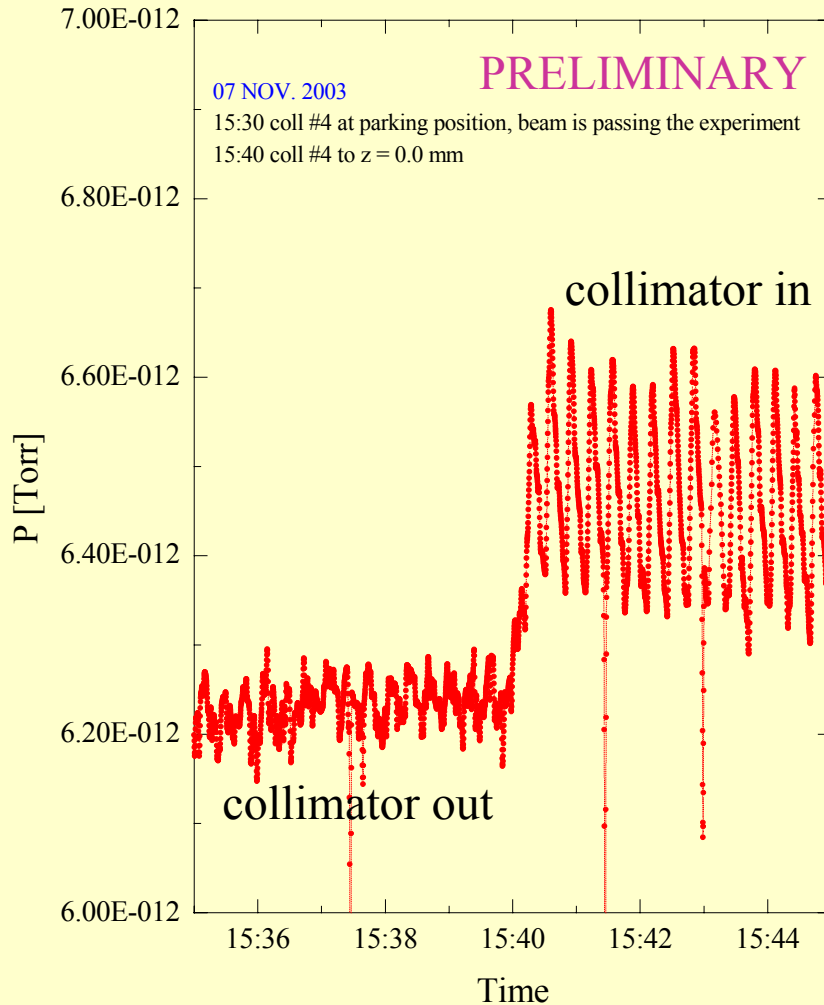
# Pressure rise with indium ions at 158 GeV/u

Grazing angle: 35 mrad, Intensity:  $1.5 \times 10^6$  ions/spill

Cu ( $1.5 \mu\text{m}$ )/Graphite



E. Mahner, E. Efthymiopoulos, J. Hansen, E. Page

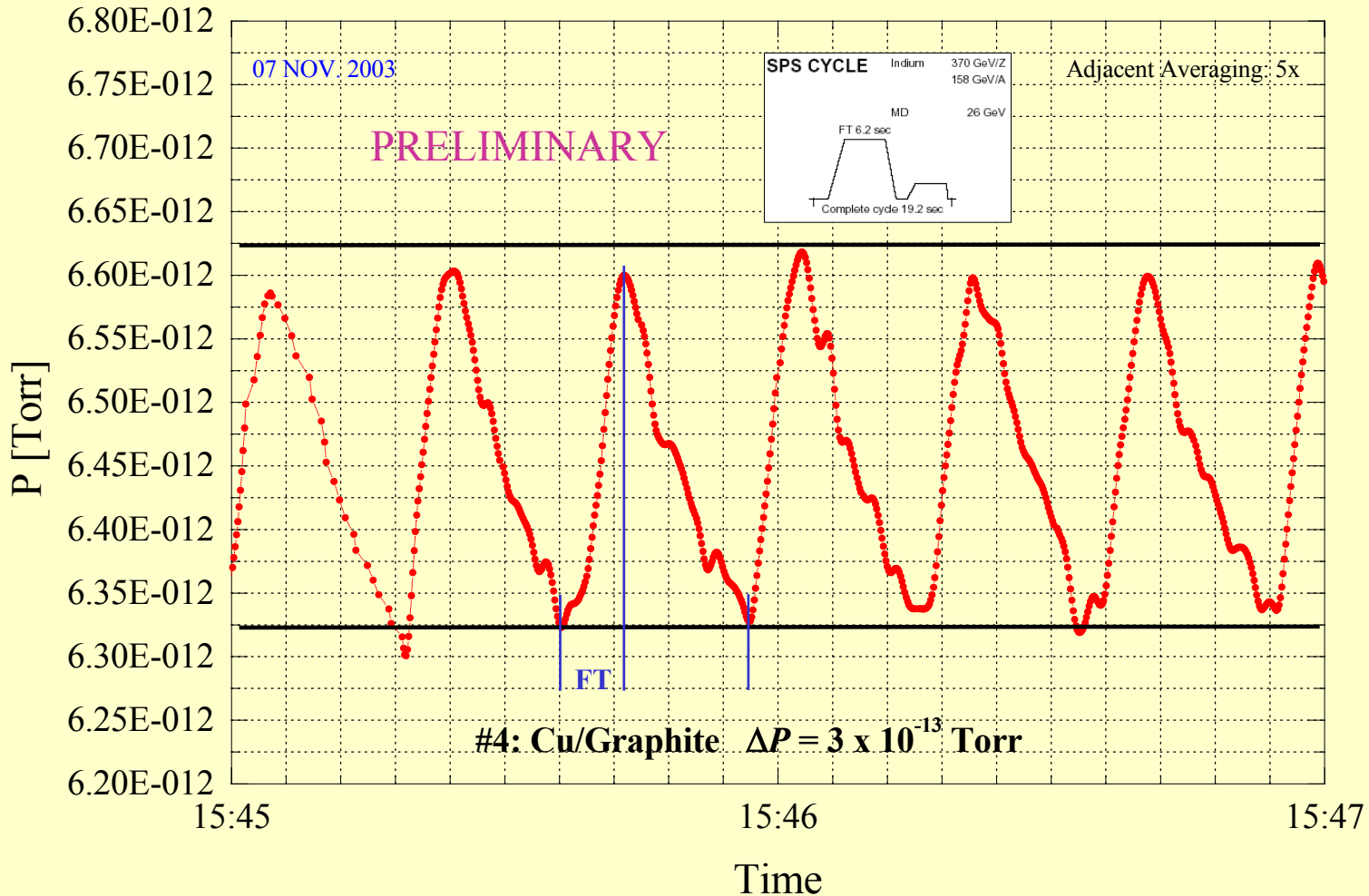




# Pressure rise with indium ions at 158 GeV/u

Grazing angle: 35 mrad, Intensity:  $1.5 \times 10^6$  ions/spill

**Cu (1.5  $\mu\text{m}$ )/Graphite**





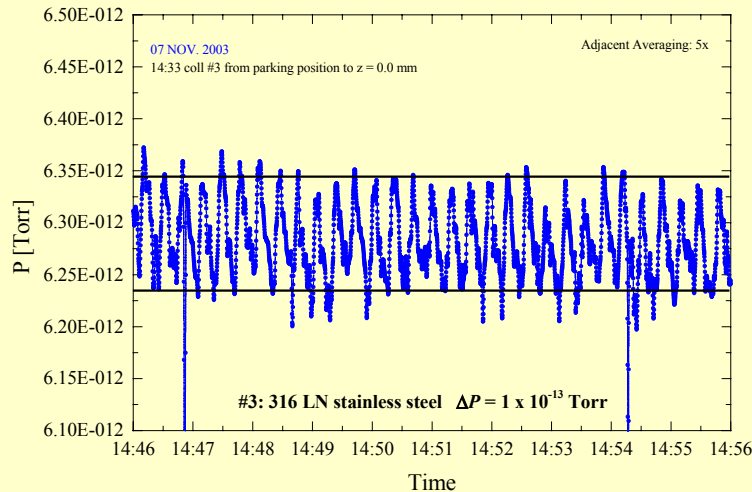
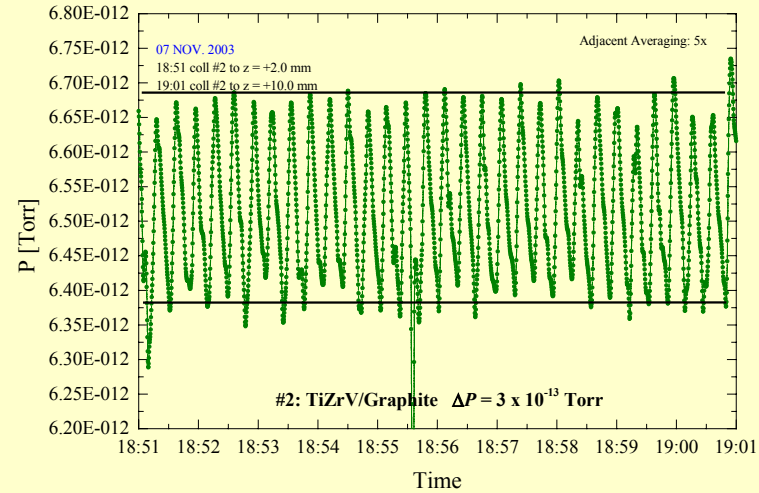
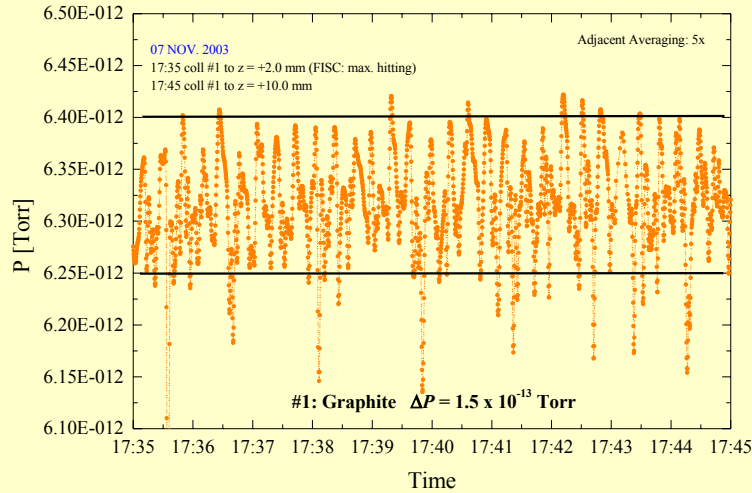
# Pressure rise with indium ions at 158 GeV/u

Grazing angle: 35 mrad, Intensity:  $1.5 \times 10^6$  ions/spill

Graphite, TiZrV (1.5  $\mu\text{m}$ )/Graphite, 316 LN ss



E. Mahner, E. Efthymiopoulos, J. Hansen, E. Page



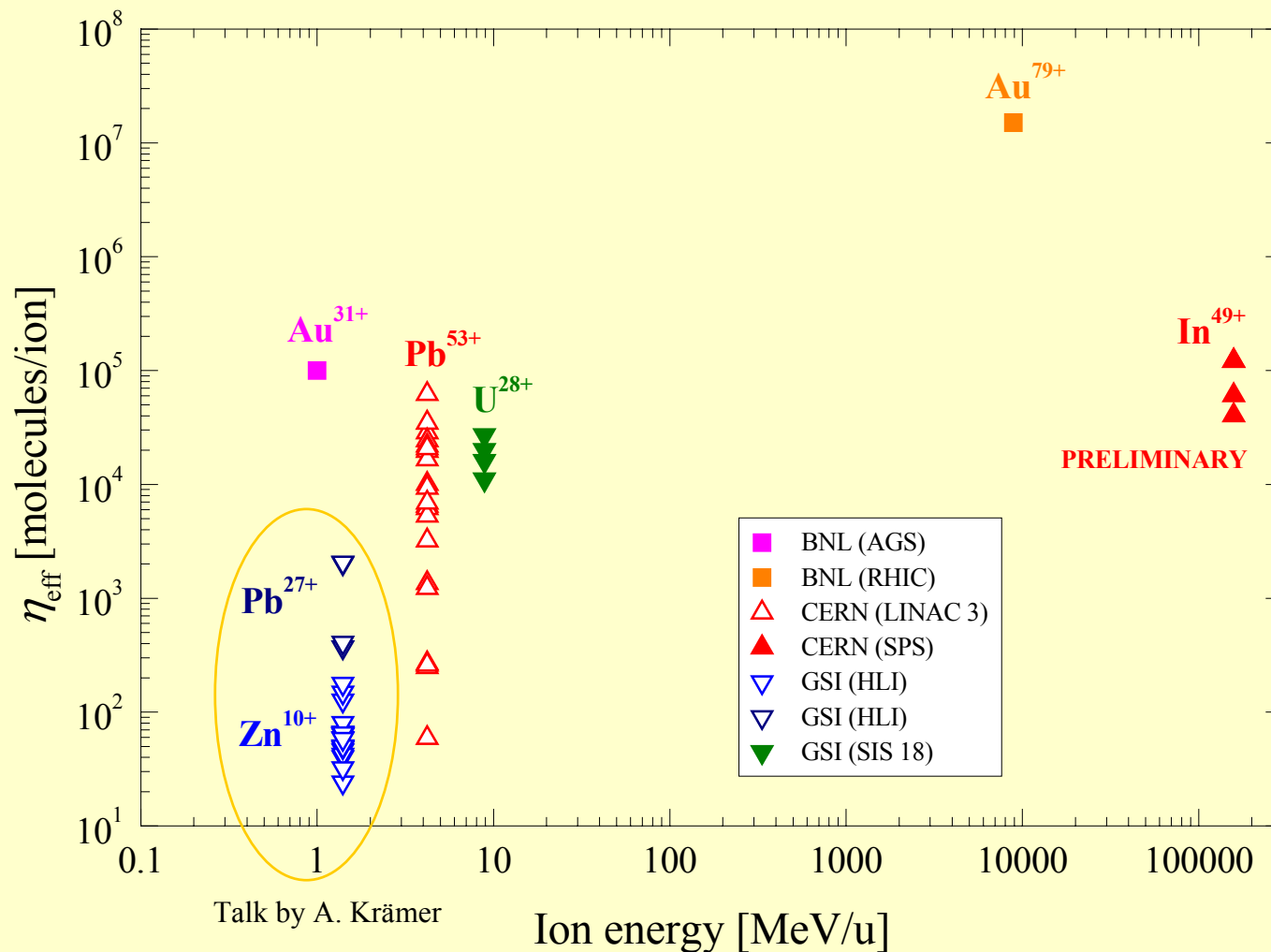
$$\eta_{eff} = \frac{\Delta P \times S}{\dot{N}_{Pb} \times k_B \times T} \approx \Delta P \times 2 * 10^{17}$$

$\Delta P$ : to correct,  $S$ : to measure,  $T$ : to calculate

PRELIMINARY desorption yields

Collimator	$\eta_{N_2}$ [molec./ion]
#1: Graphite	$\sim 6 \times 10^4$
#2: TiZrV/Graphite	$\sim 1.2 \times 10^5$
#3: 316 LN stainless steel	$\sim 4 \times 10^4$
#4: Cu/Graphite	$\sim 1.2 \times 10^5$

# Heavy-ion induced desorption data: Overview





# *Acknowledgements*

## *AT, AB, EST, GSI, BNL collaboration*



- **LINAC 3 desorption studies**
  - C. Hill, D. Küchler, M. O’Neil, R. Scrivens, J. Broere, R. Hajdas, M. Chanel, C. Lacroix, D. Möhl, K. Schindl
  - A. Lasserre, C. Benvenuti, S. Calatroni, P. Chiggiato, P. Costa Pinto, G. Favre, G. Jesse, M. Malabaila, M. Taborelli, T. Tardy, W. Vollenberg,
  - D. Allard, J.P. Bertuzzi, I. Collins, O. Gröbner, N. Hilleret, J. Hansen, J.M. Laurent
  - N. Madsen, K. Magyari, E. Page, J.P. Pasquet, S. Southern, P. Strubin
- **GSI & BNL collaboration**
  - M. Bender, O. Boine-Frankenheim, H. Kollmus, A. Krämer, H. Reich-Sprenger
  - W. Fischer, H.C. Hseuh, S.Y. Zhang
- **SPS desorption experiment**
  - O. Aberle, G. Arduini, M. Chanel, E. Chiaveri, I. Efthyiopoulos, J. Genest  
J. Hansen, E. Page, K. Schindl